



CNR-INO
ISTITUTO NAZIONALE DI OTTICA
CONSIGLIO NAZIONALE DELLE RICERCHE

LASERS FOR NOVEL ACCELERATORS

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**10th International Particle Accelerator
Conference IPAC19**
MELBOURNE CONVENTION &
EXHIBITION CENTRE, AUSTRALIA
19 – 24 MAY 2019

www.ino.cnr.it

CNR Campus in Pisa



Consiglio Nazionale delle Ricerche
Area della Ricerca di Pisa

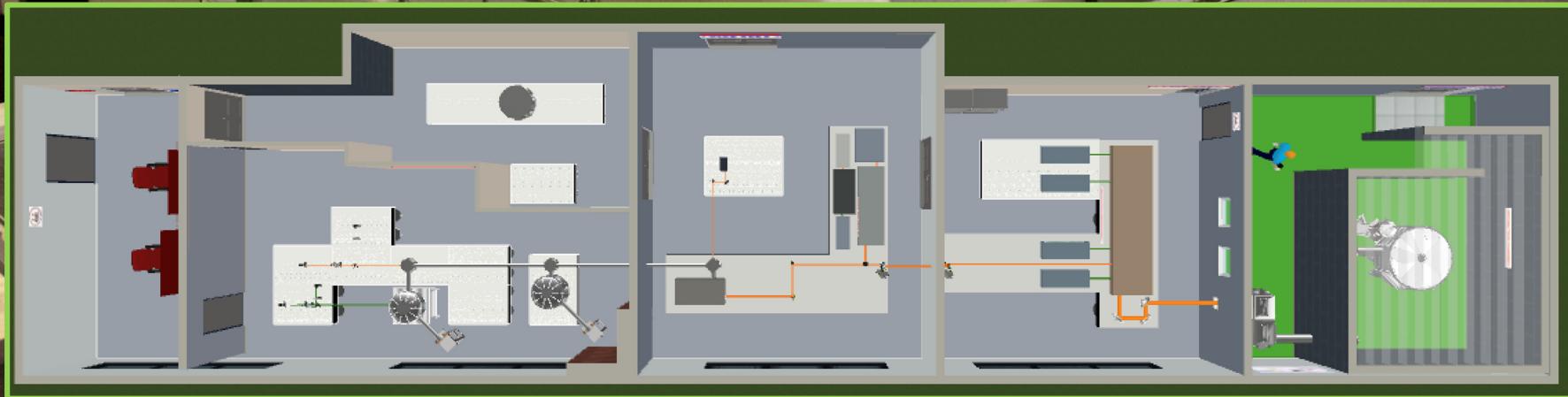
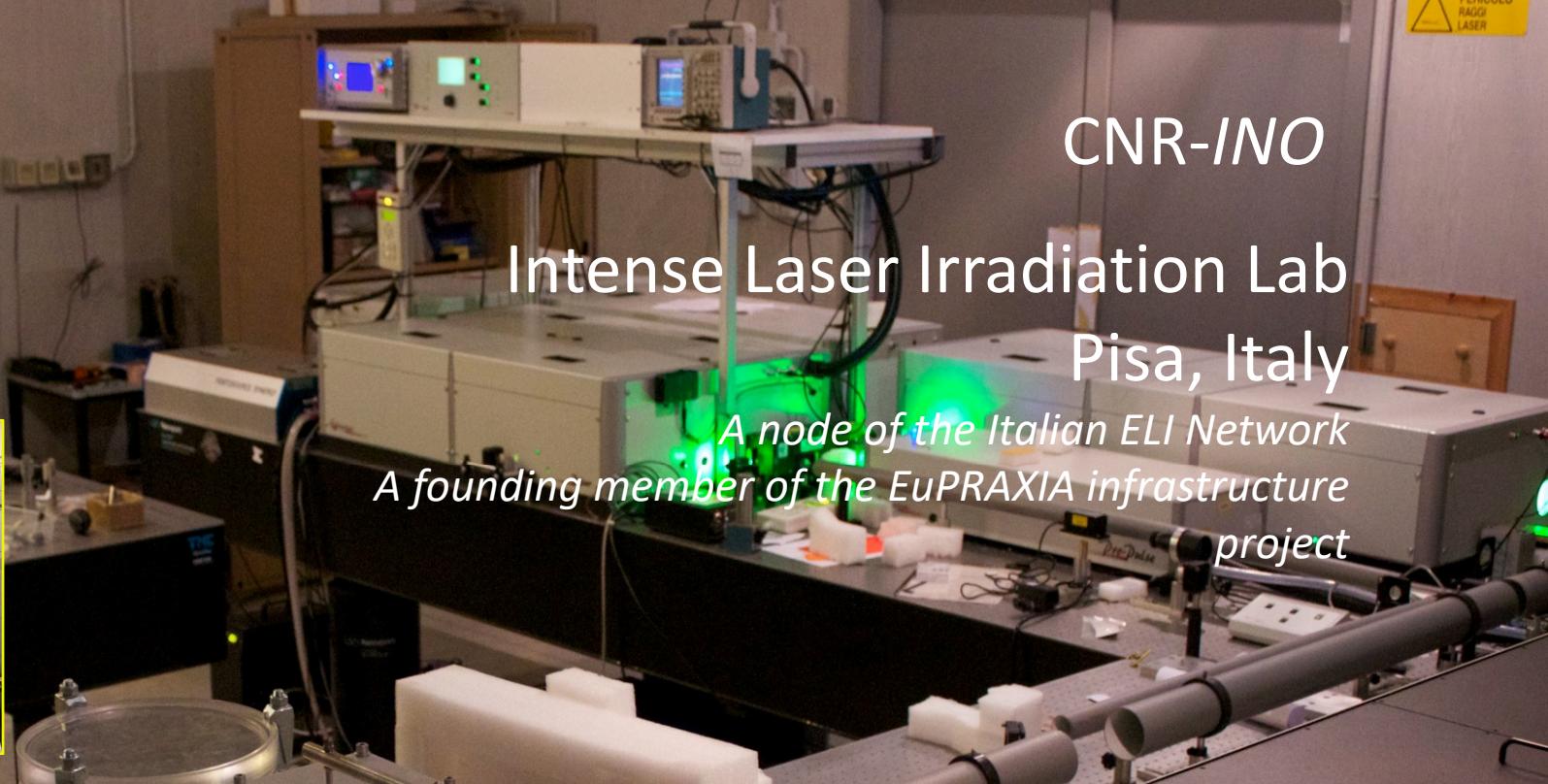




CNR-INO

Intense Laser Irradiation Lab Pisa, Italy

*A node of the Italian ELI Network
A founding member of the EuPRAXIA infrastructure project*



<http://www.ilil.ino.it>

Intense Laser Irradiation Laboratory

Istituto Nazionale di Ottica – Consiglio Nazionale delle Ricerche



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Contents

- High Intensity Lasers
- Laser drivers for plasma accelerators
- Today's viable solution
- Next steps
- Summary

Laser, “a solution seeking for a problem”*

T. Maiman, New York Times, May 6, 1964

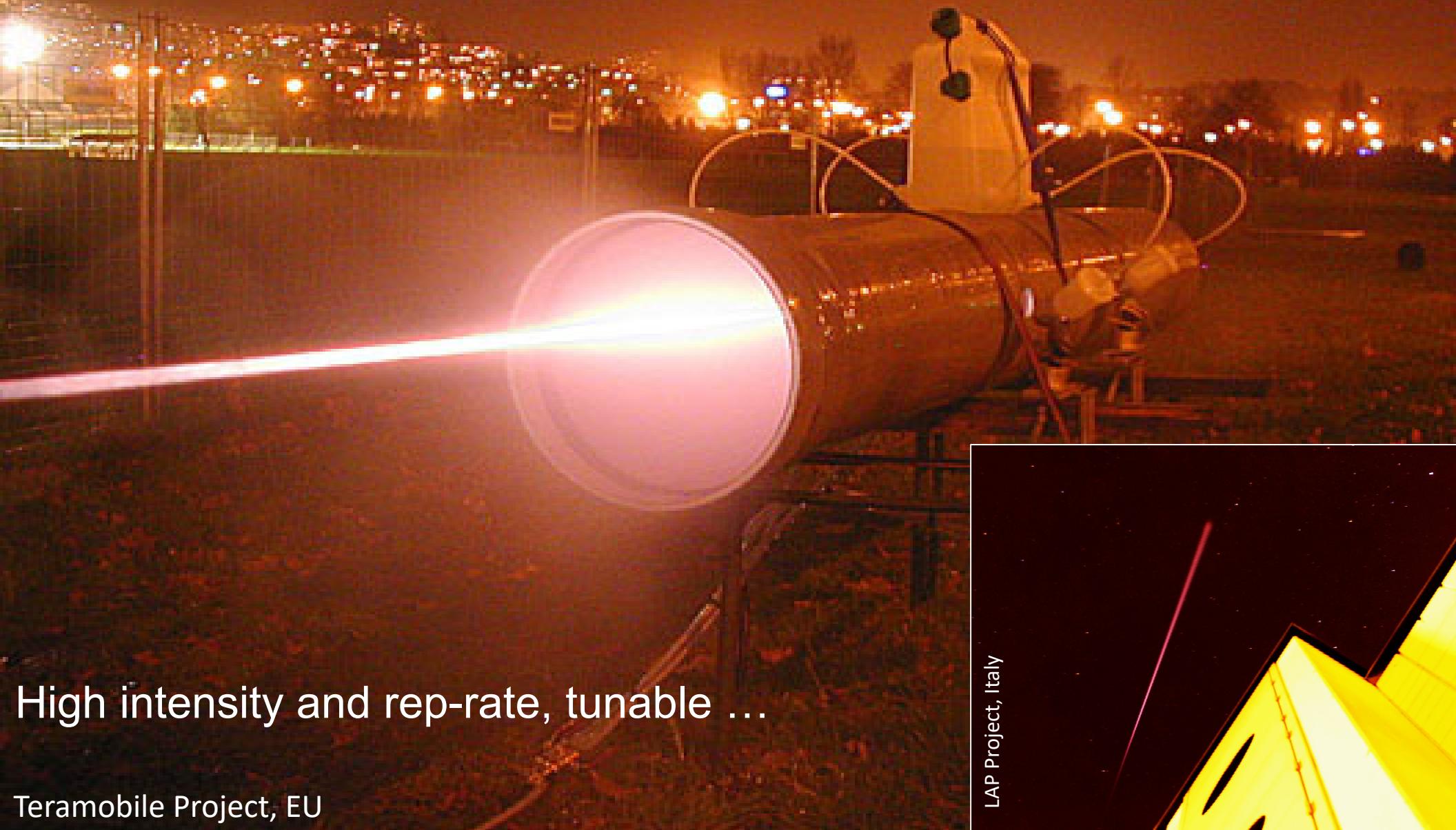
LASER DRIVER FOR FAST MINI-PROBES TO
EXTRASOLAR PLANETS

Laser -driven de-orbiting of debris



High peak and average power, compactness, efficiency ...

Atmospheric Propagation



High intensity and rep-rate, tunable ...

Teramobile Project, EU

LAP Project, Italy

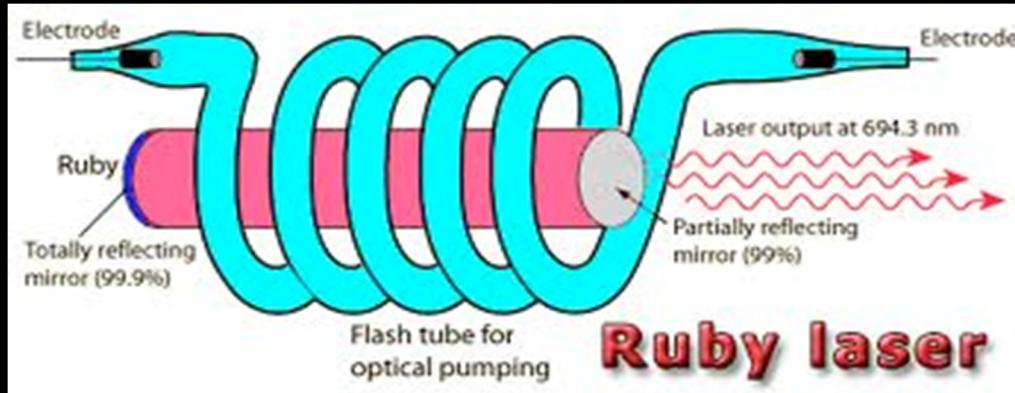
Lightning control



AIP Advances 2, 012151 (2012); doi:10.1063/1.3690961



The origin of lasers in the lab

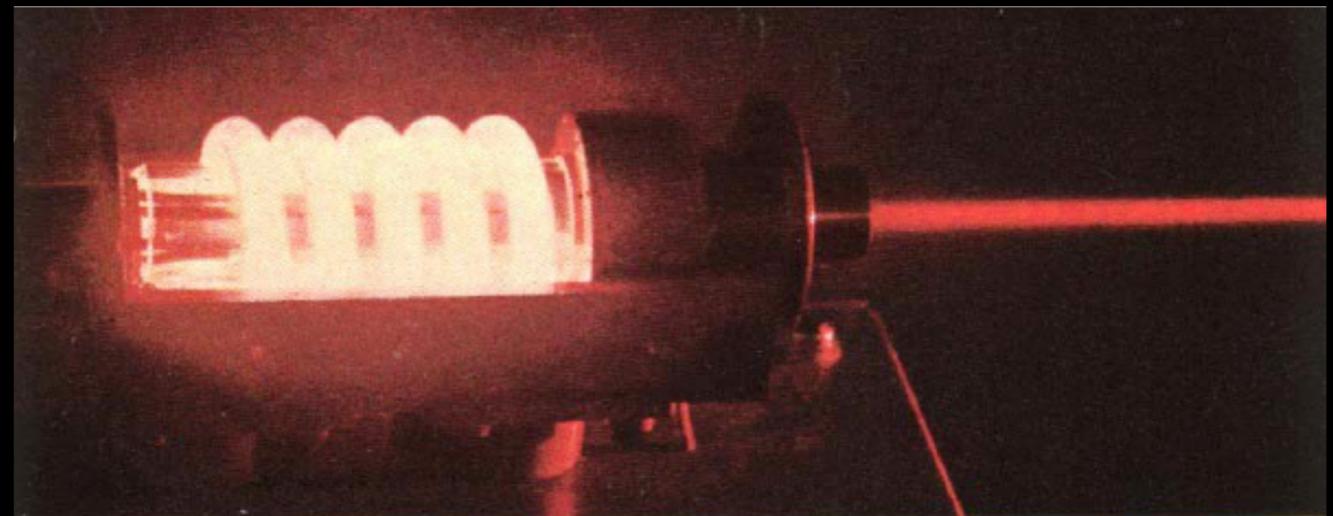


High power laser pulses
≈ nanosecond pulse duration Q-switch
Power: ≈ GW

Theodore Maiman, 1960



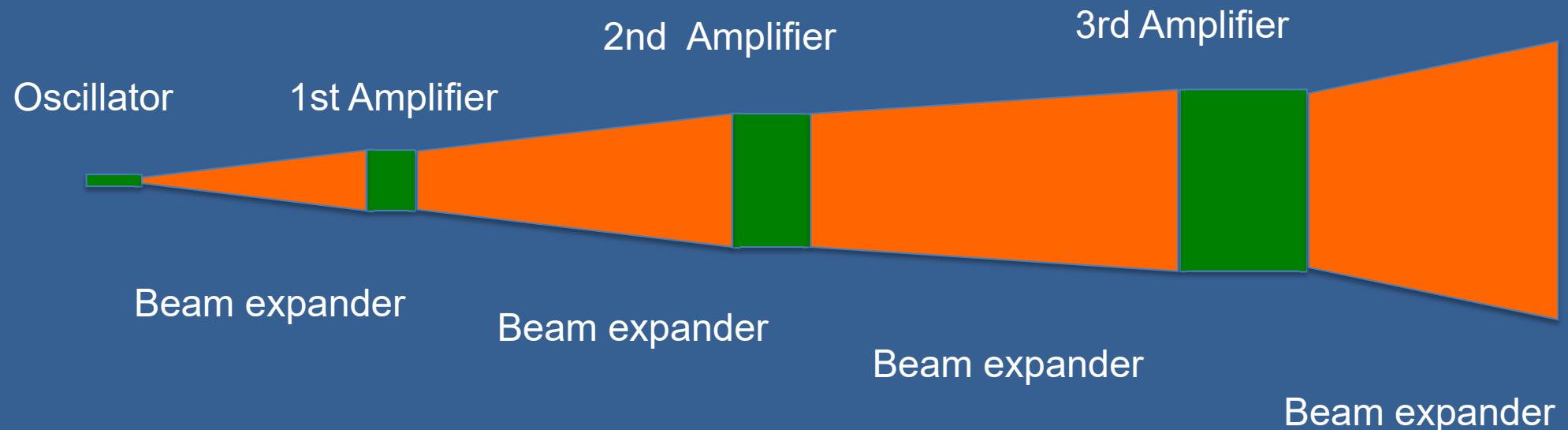
C.H. Townes, N.G.Basov and A.M.Prokhorov, Physics Nobel prize, 1964



DAMAGE constraints FOR AMPLIFICATION



To avoid damage of optics and gain materials, laser intensity must be distributed over progressively larger diameters



Consequence? “**Gigantism**” of high power, high energy lasers ...

Conventional high power (high energy) lasers have a huge size



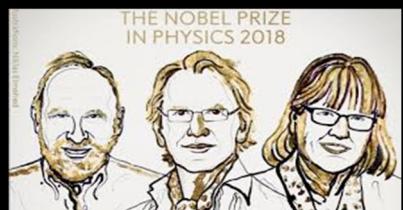
Lawerence
Livermore
National Lab.
California, USA

Alternative approach to some laser-matter interaction applications? High power at low energy per pulse.

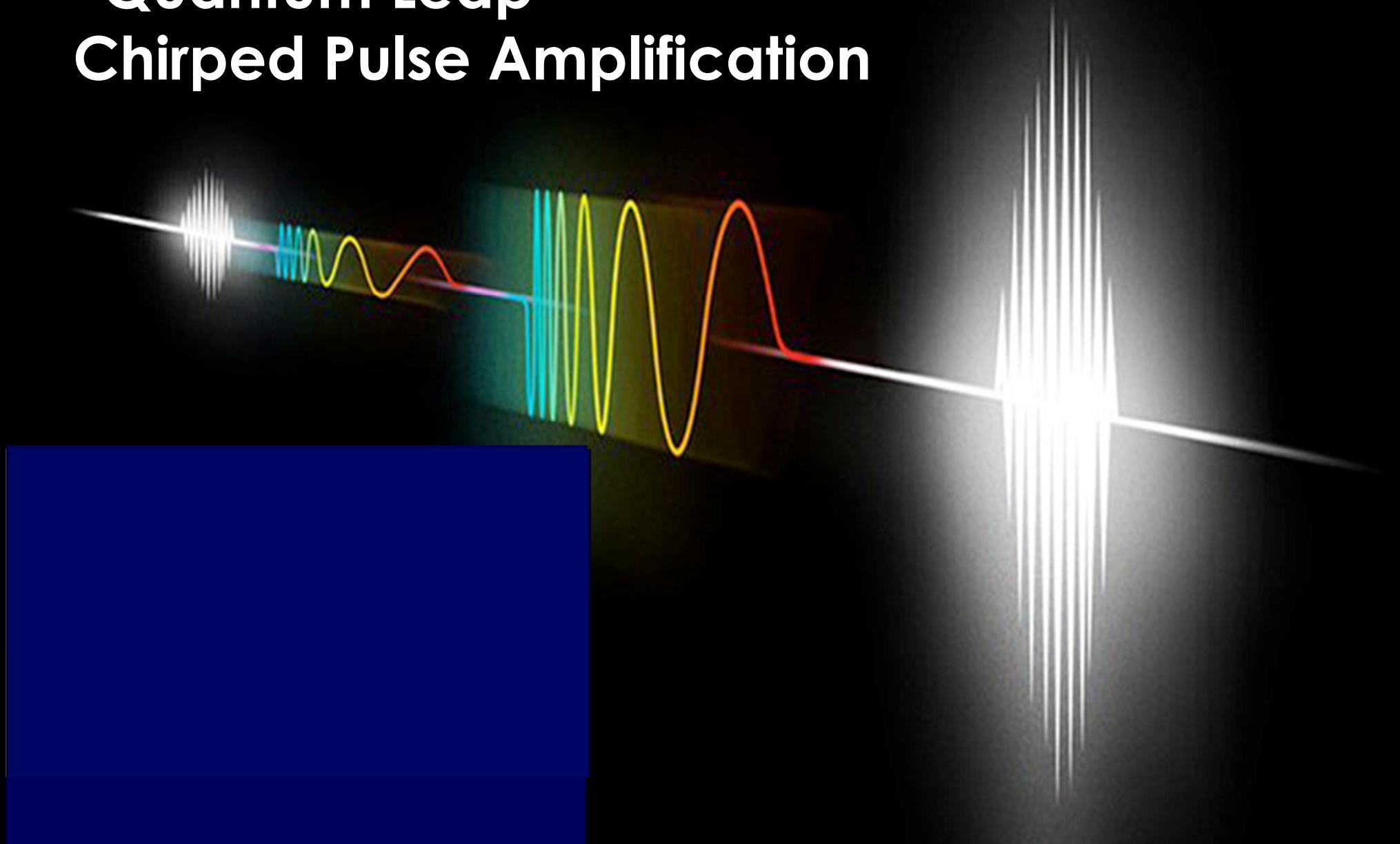
“Quantum Leap” Chirped Pulse Amplification

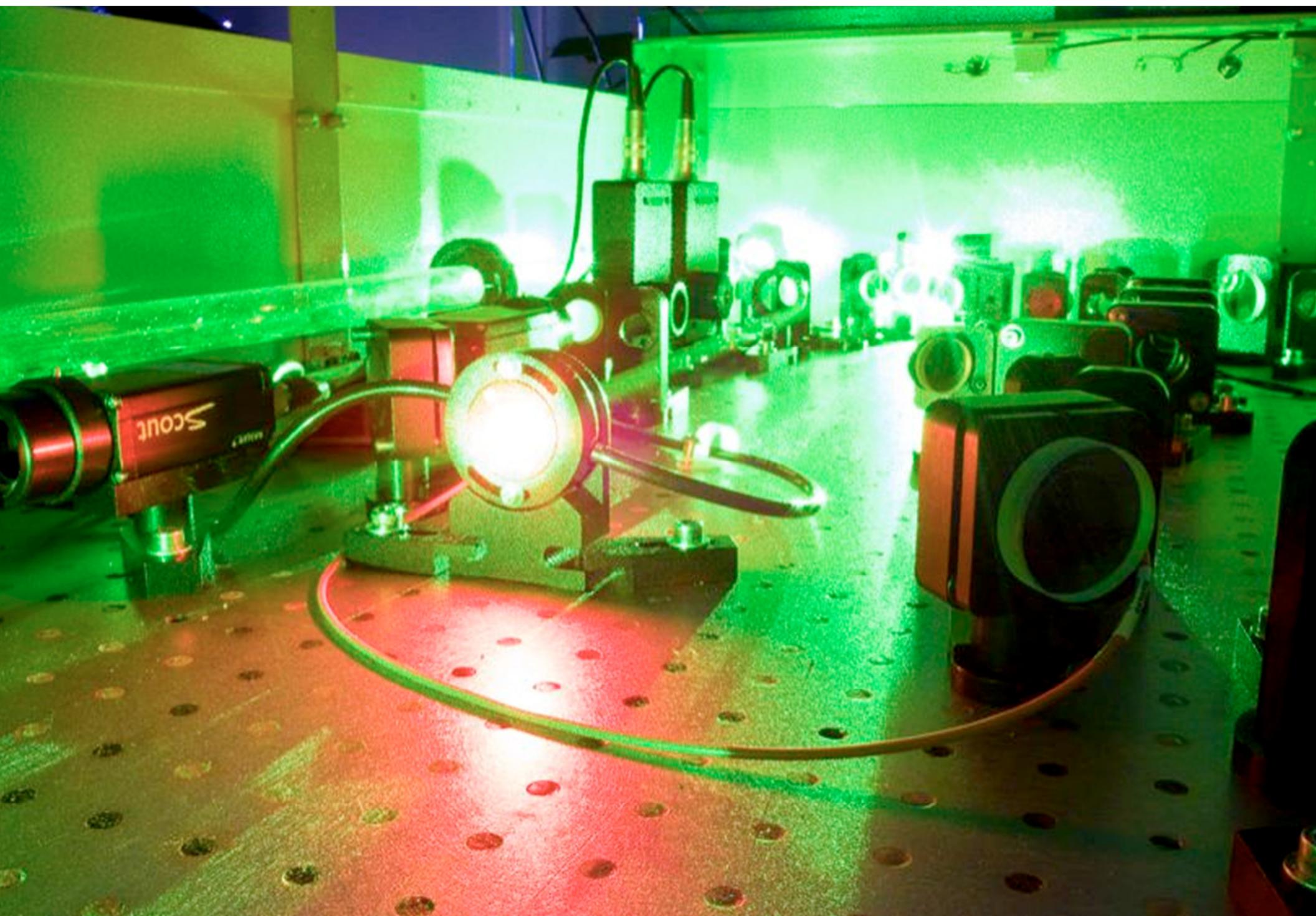


D. Strickland and G. Mourou, “Compression of
amplified chirped optical pulses”, Opt. Commun.
56, **219** (1985)

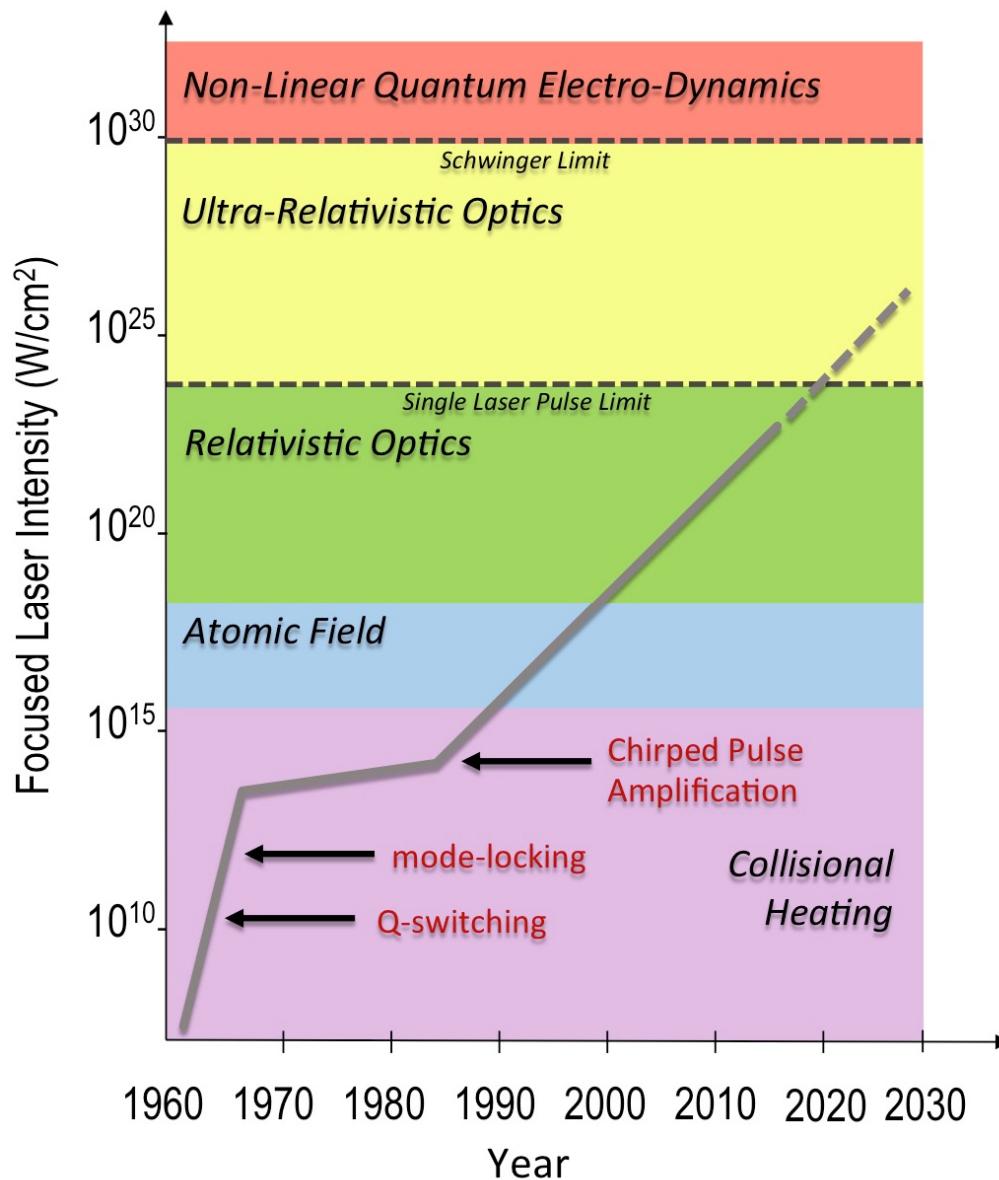


“Quantum Leap” Chirped Pulse Amplification





Evolution of high intensity lasers



ICUIL World Map of Ultrahigh Intensity Laser Capabilities



The original idea of Laser driven acceleration

VOLUME 43, NUMBER 4

PHYSICAL REVIEW LETTERS

23 JULY 1979

Laser Electron Accelerator

T. Tajima and J. M. Dawson

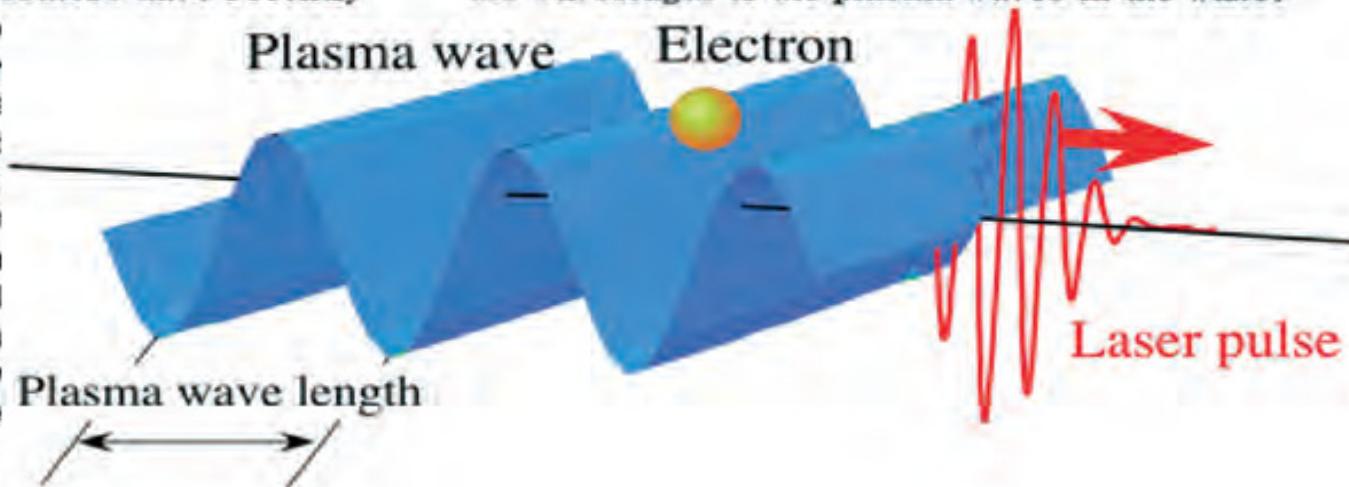
Department of Physics, University of California, Los Angeles, California 90024

(Received 9 March 1979)

An intense electromagnetic pulse can create a wake of plasma oscillations through the action of the nonlinear ponderomotive force. Electrons trapped in the wake can be accelerated to high energy. Existing glass lasers of power density 10^{18} W/cm^2 shone on plasmas of densities 10^{18} cm^{-3} can yield gigaelectronvolts of electron energy per centimeter of acceleration distance. This acceleration mechanism is demonstrated through computer simulation. Applications to accelerators and pulsers are examined.

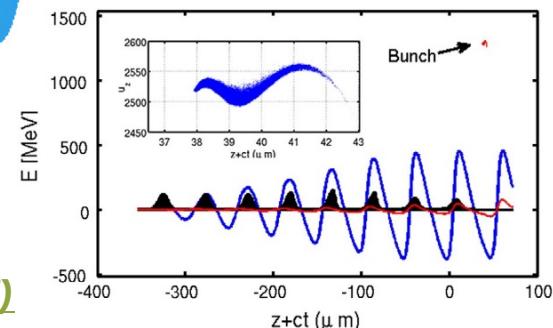
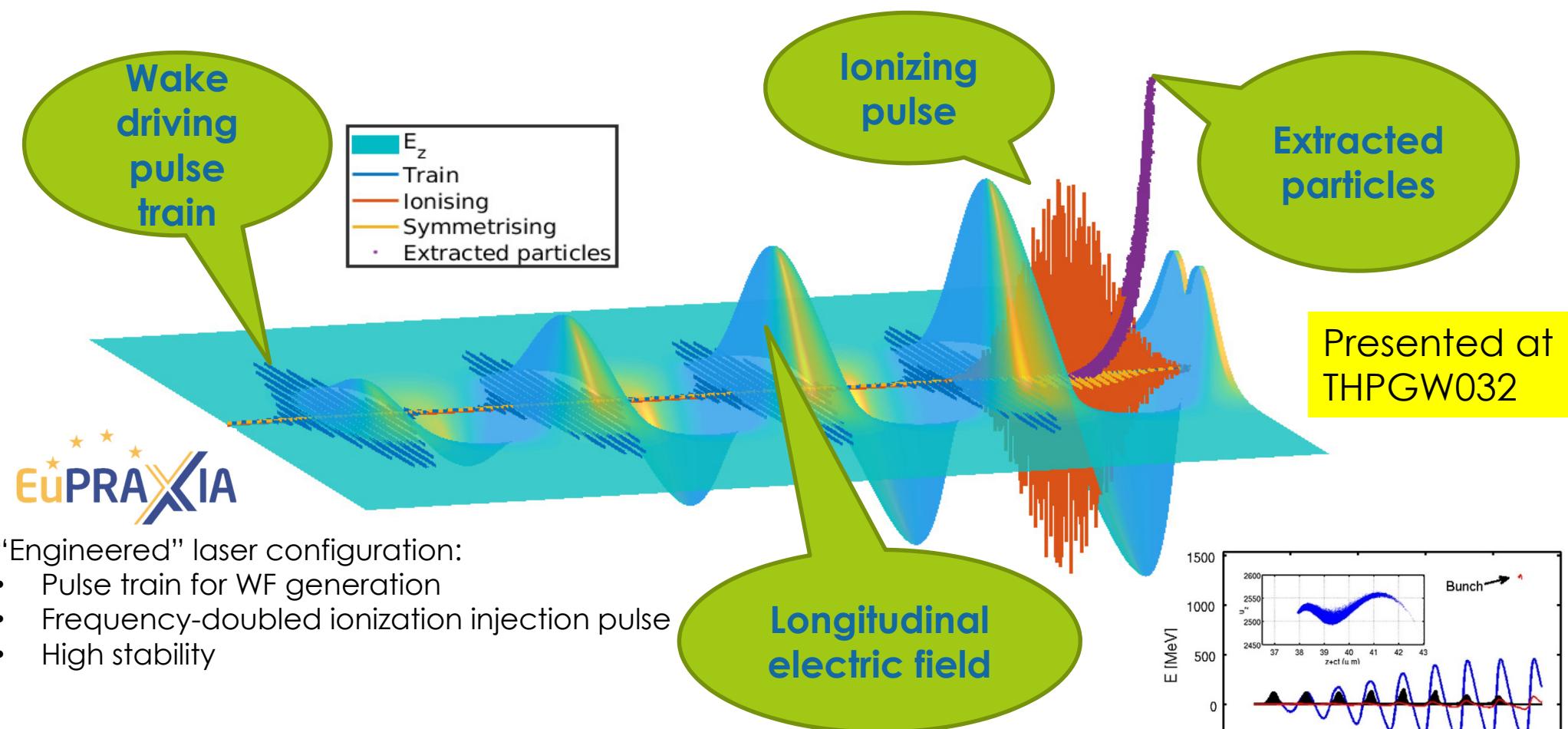
Collective plasma accelerators have recently received considerable attention. Eralan² considered cosmic-ray generation by moving magnetic field kinetic waves.² In terms of today's technology for collective present-day electron beam of $\sim 10^7 \text{ V/cm}$ and power density $\sim 10^{18} \text{ W/cm}^2$. On the other hand, the glass lasers capable of delivering a power density 10^{18} W/cm^2 , and, as we shall see

the wavelength of the plasma waves in the wake:



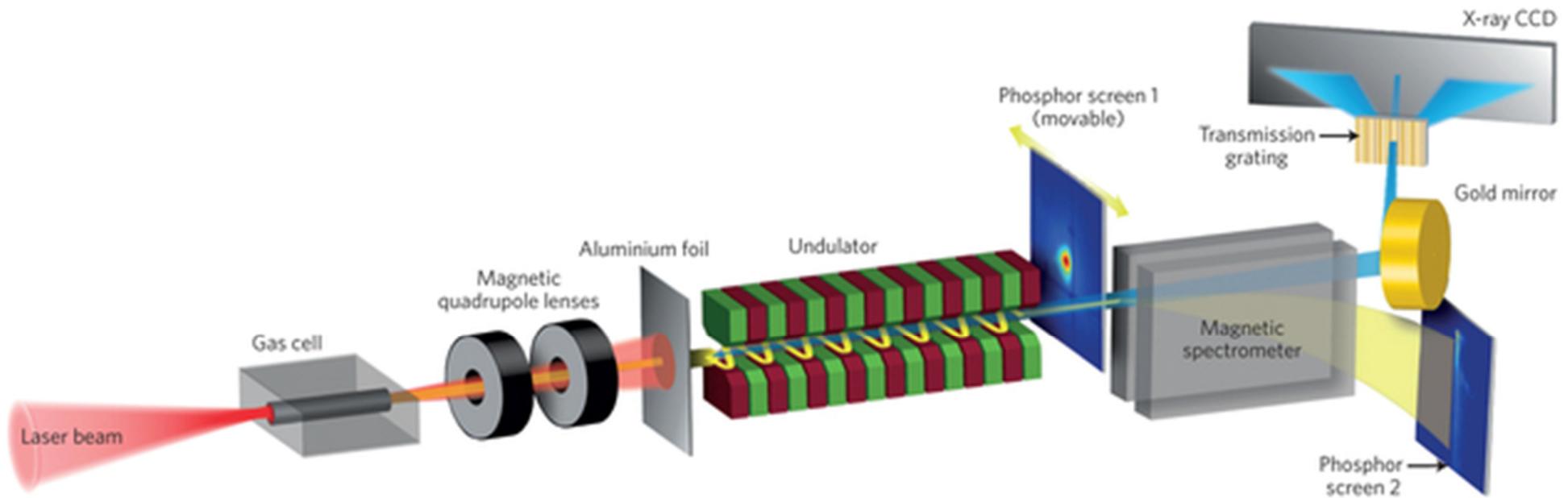
Advanced LWFA schemes

Example of advanced scheme for high quality laser-plasma acceleration: REMPI⁽¹⁾



Plasma based X-Ray Free Electron Laser?

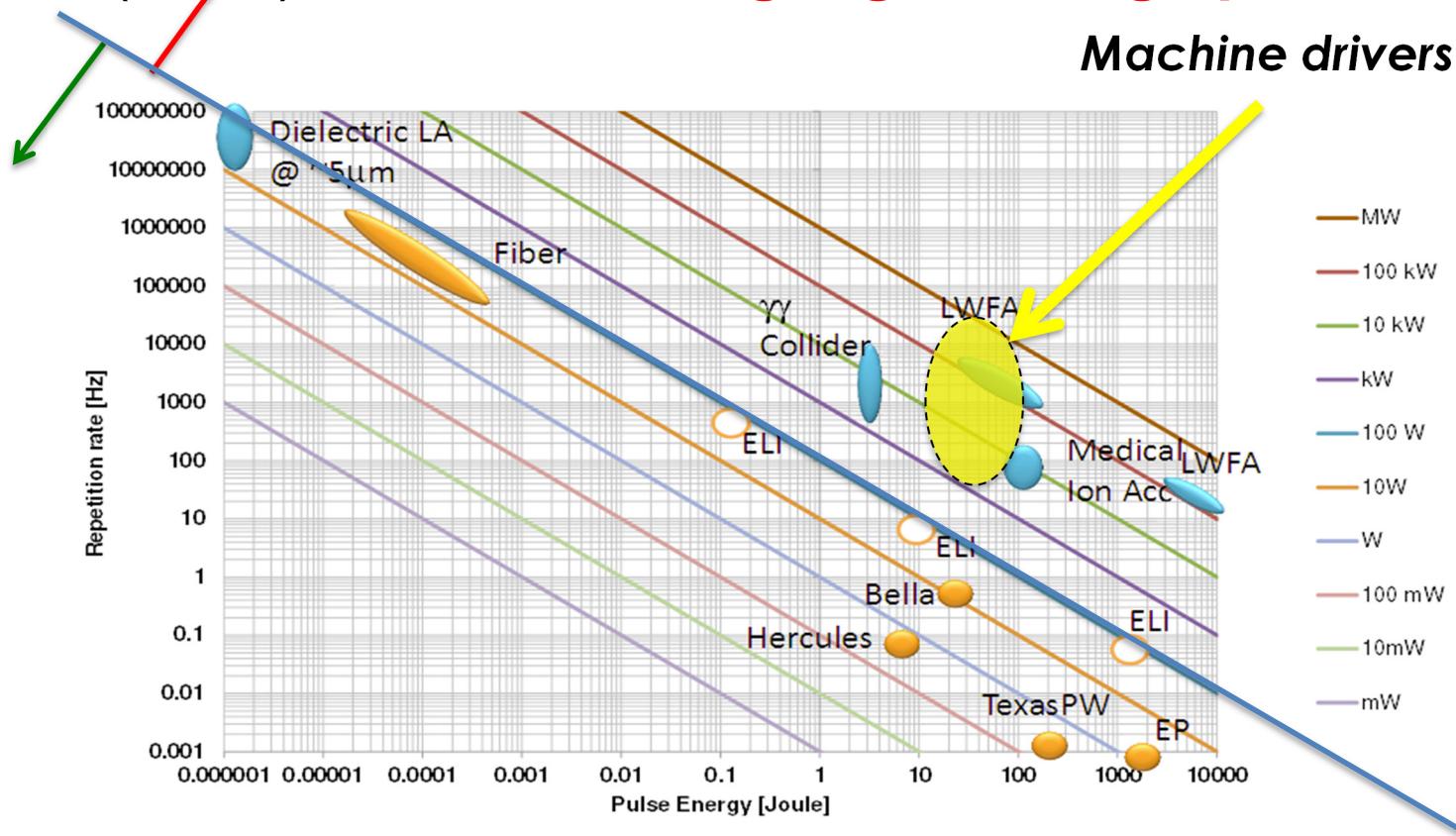
High quality GeV electron beam needed: **a test bed for plasma acceleration**
Great effort world-wide towards this challenging objective (see ME Cuprie's slides)



Aiming at user operation sets mandatory operation boundaries in terms of rep-rate, reliability, up-time, flux excetera. **Driving laser is a key enabling component.**

NEEDED HIGH POWER LASERS

Needs emerging for a PW-class system, with high repetition rate (\approx kHz) and **demanding high average power**



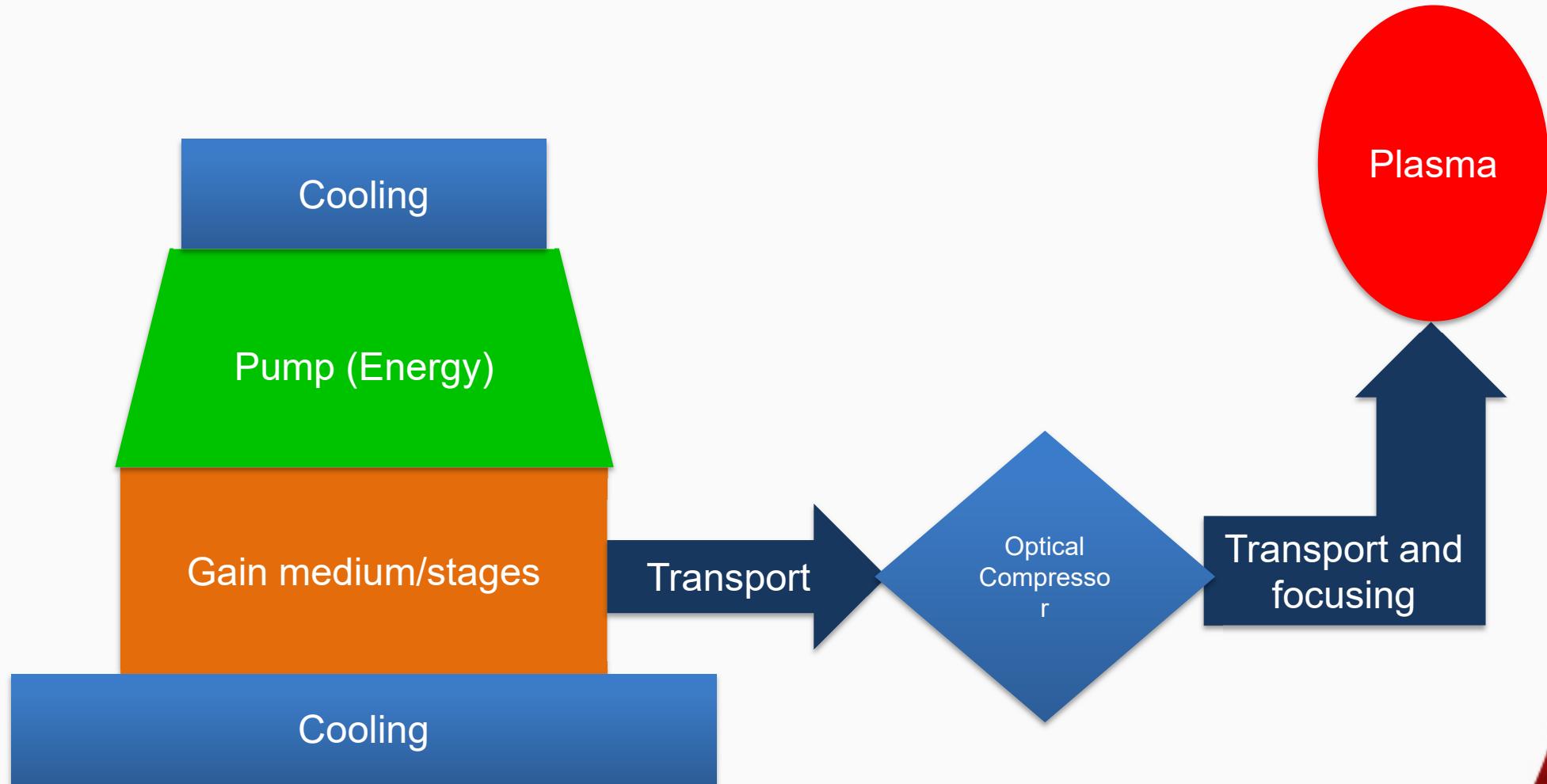
Major effort required to fill the gap between **existing** and **required** laser technology

KEY REQUIRED LASER FEATURES

- Short pulse **PW-kW** laser technology (CPA, diode pumping);
- **High repetition rate** to allow user operation while enabling active stabilization via feedback loops;
- **Average power** ranging from 1kW to 10 kW;
- Controlled **beam transport**, focusing, diagnostics.
- Main **issues**: pump lasers, amplifiers heat management and compressor gratings at high rep-rate.

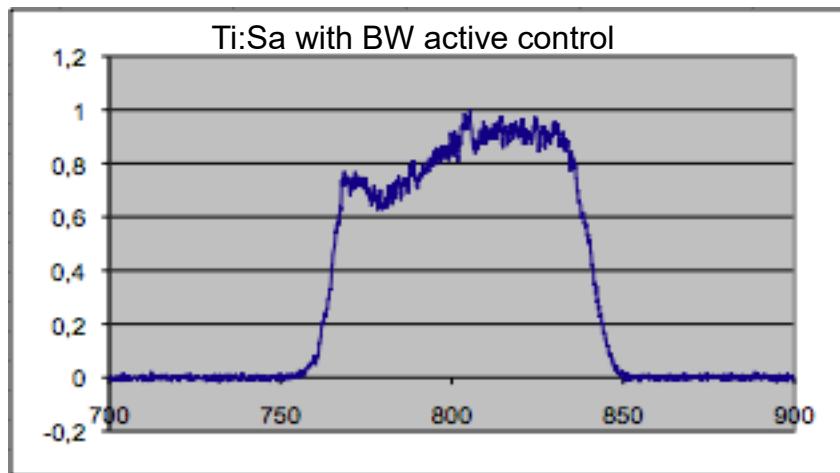
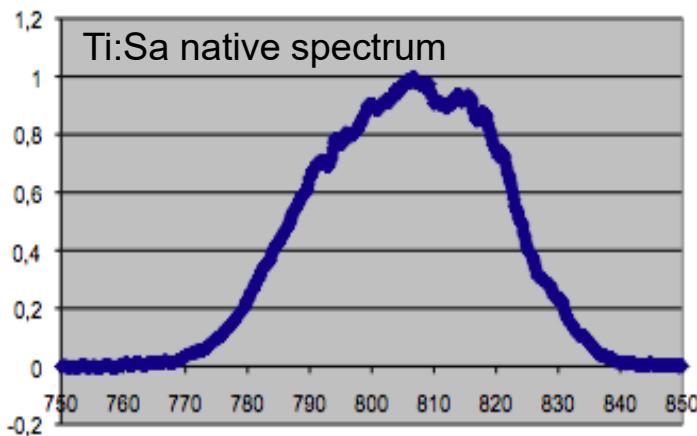


RELEVANT BLOCKS OF A LASER DRIVER



GAIN MATERIAL: TITANIUM SAPPHIRE

Currently, most PW-scale CPA lasers are based on Ti:Sapphire pumped by frequency doubled Nd:YAG lasers



- Large gain bandwidth (680 nm – 1080 nm)
- High quantum efficiency
 - Long lifetime: 3 μs
 - Thermal conductivity: $35 \text{ WK}^{-1}\text{m}^{-1}$
 - Pumped in the green

**Active bandwidth control crucial to
overcome gain narrowing and enable sub-50 fs pulses**

KEY PARAMETERS OF LASING MEDIA

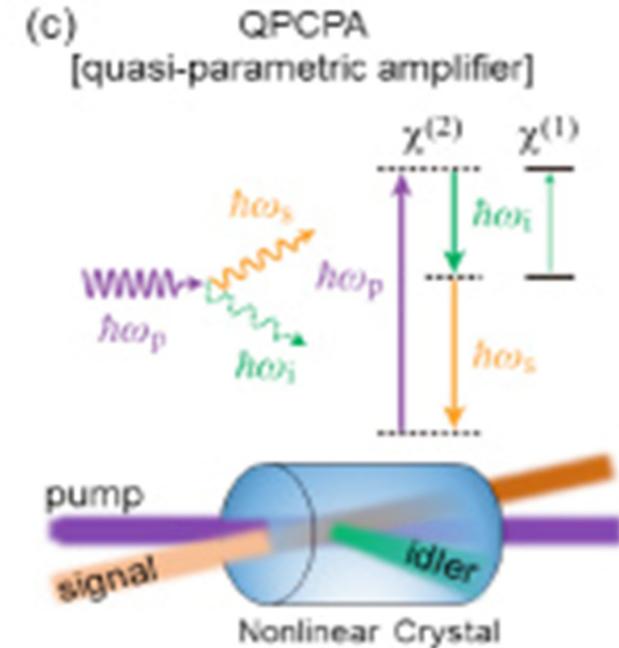
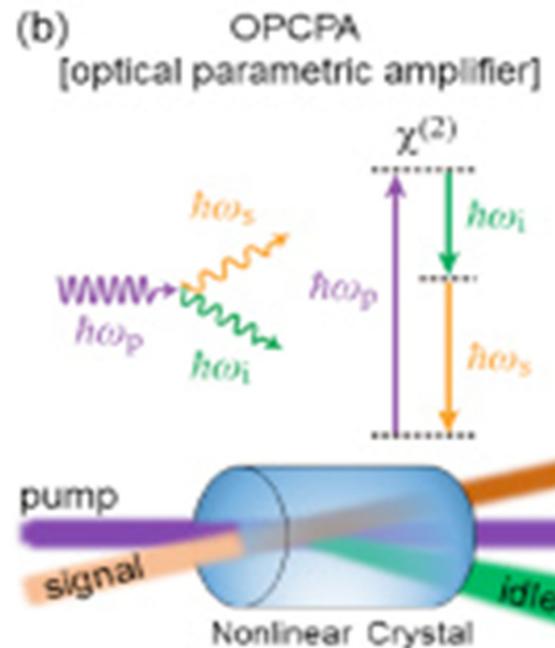
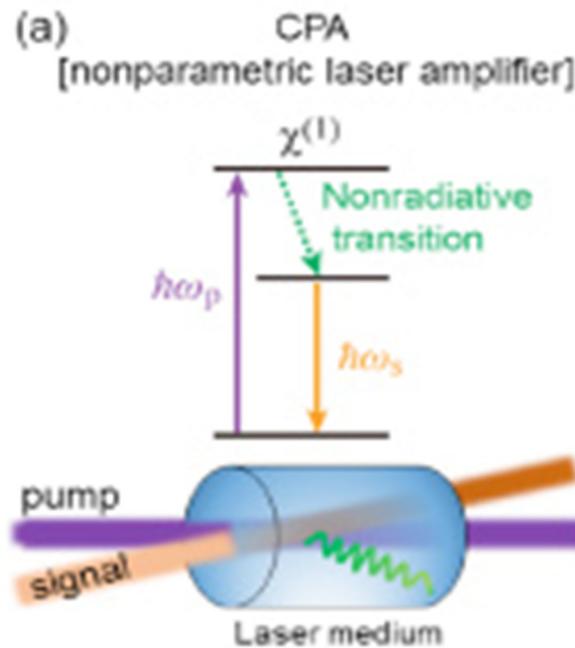
Main parameters governing laser amplifiers:

- Spectral gain **bandwidth**: short pulse duration
- **Thermal conductivity**: limits repetition rate
- Abs. and emis. **cross sections**: gain, pump absorption and saturation
- **Fluorescence lifetime**: sets conditions on pumping
- **dn/dT** : limits beam quality

Crystals	Nd: YAG	Yb: YAG	Ti: Sa	Yb: CaF ₂
Fluorescence lifetime (ms)	0.23	0.96	0.0032	2.4
Stimulated-em. $\sigma (\times 10^{-20}/\text{cm})$	20 to 30	2.1	30	0.2
Fluorescence wavelengths (nm)	1064	1030	660-1100	1033
Absorption wavelengths (nm)	808	940	514 to 532	980
Fluorescence BW (FWHM) (nm)	0.67	10	440	70
Absorption BW (FWHM) (nm)	1.9	>10	200	10
Pumping quantum efficiency	0.76	0.91	0.55	0.5
Saturation fluence (J/cm ²)	0.67	9.2	0.9	80
Thermal conductivity (W/m/°K)	0.14	11	35	9.7
dn/dT (1E-6/K)	7.3	7.8	13	-11.3

ALTERNATIVE APPROACH

Optical Parametric Chirped Pulse Amplification



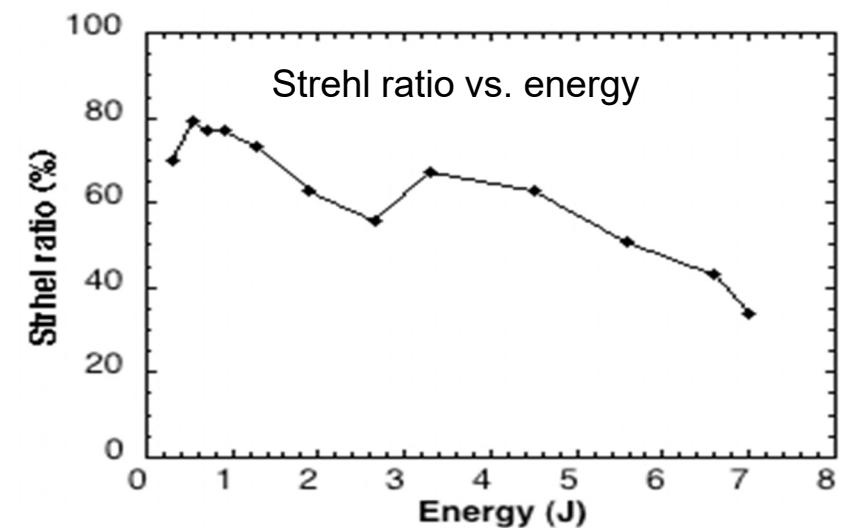
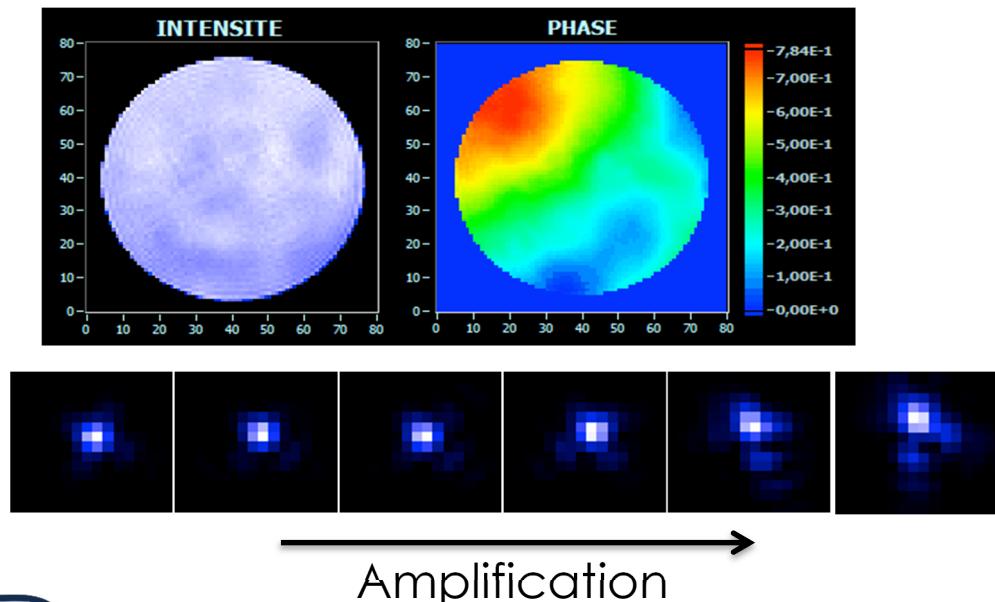
Mainly for ultra-broad-band front-end preamplifiers

FOCAL SPOT BEAM QUALITY

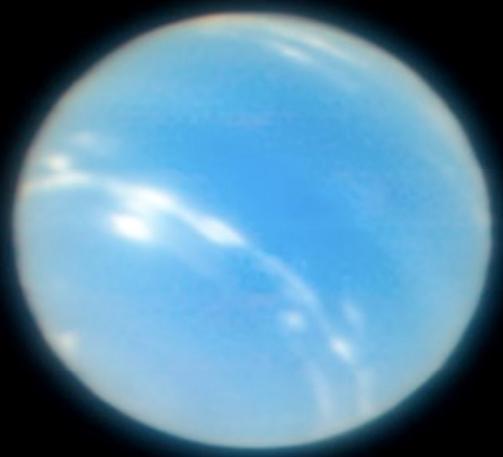
As larger gain media and optics are used, optical aberrations become important and limit the focusability of laser pulses

$$S_r = \frac{\text{Energy in the focal spot}}{\text{Energy in the pulse}} \quad \text{STREHL RATIO}$$

PHASE FRONT DISTORTIONS



Borrowing Astronomy Adaptive Technology



Adaptive optics



No Adaptive optics

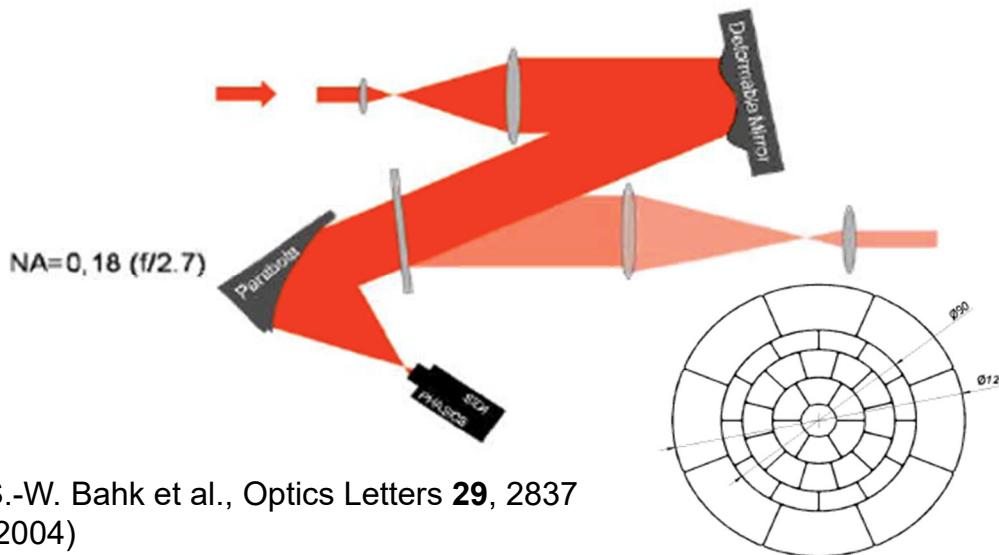
ESO's Very Large Telescope (Paranal, Chile)

ADAPTIVE OPTICS for high power lasers

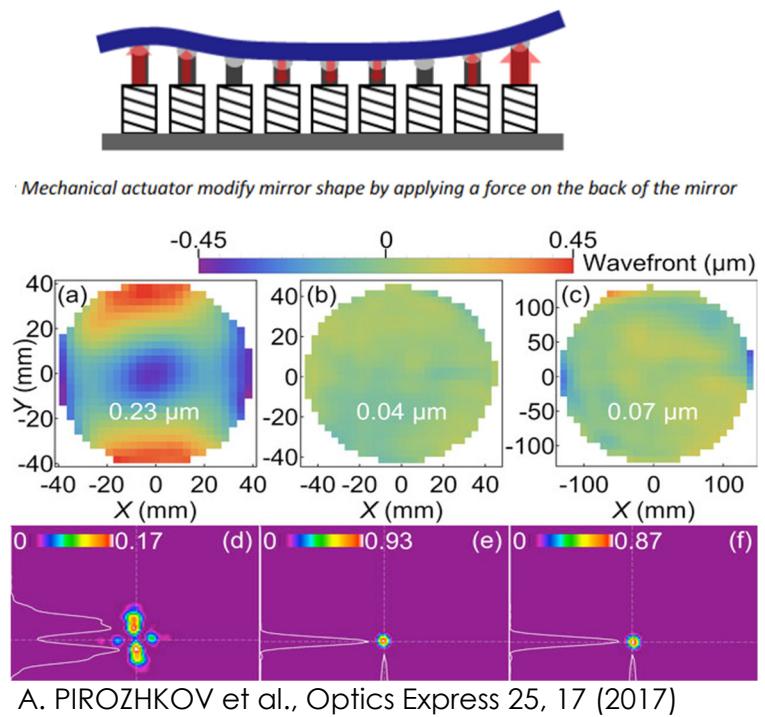
Active spatial phase control technique can be used to **correct severe to moderate phase distortions**;

Sensors are used to measure intensity and **phase map** of the beam;

Deformable mirrors are used to correct the measured wave front distortions in a closed loop;

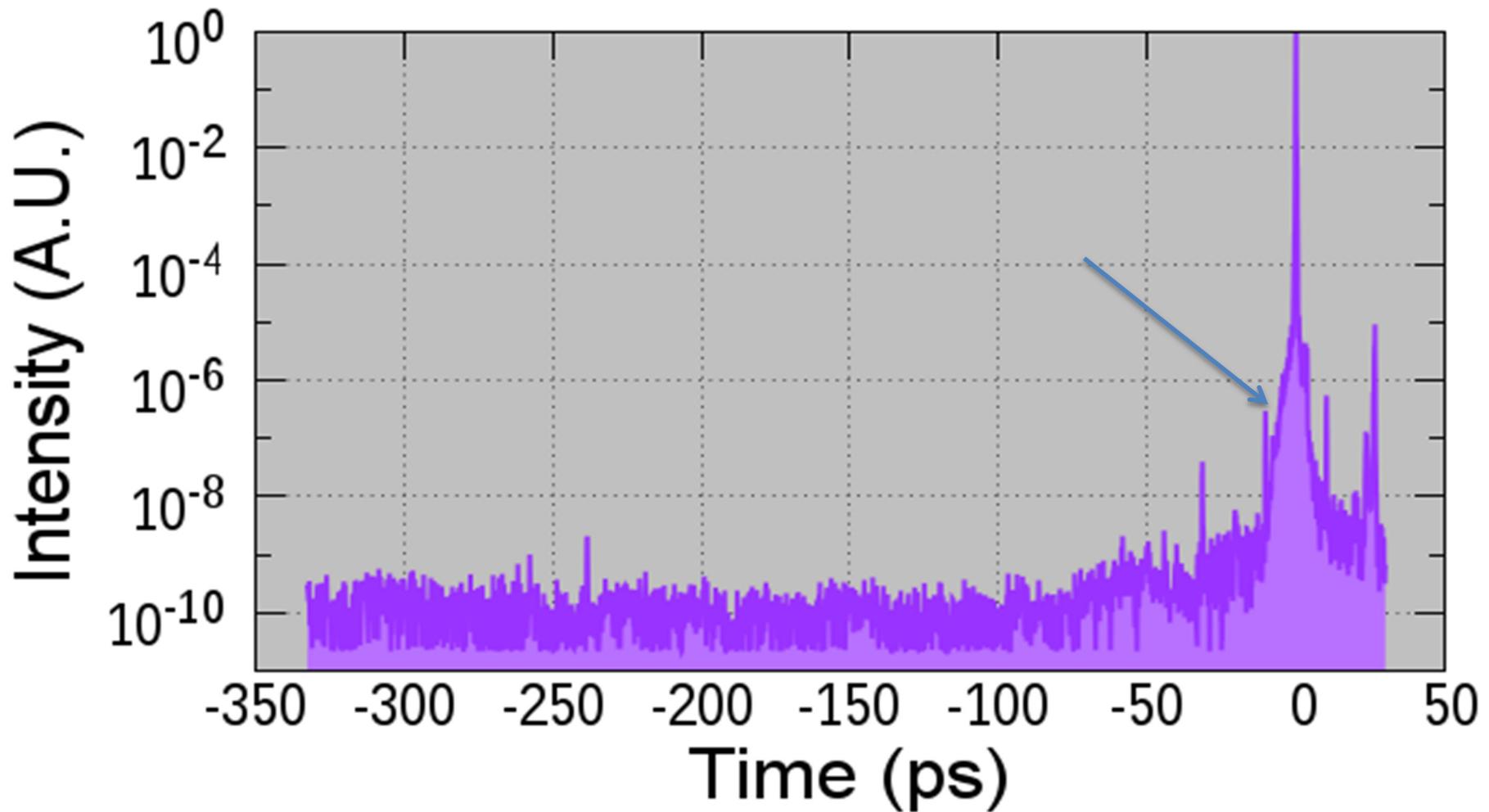


S.-W. Bahk et al., Optics Letters 29, 2837 (2004)

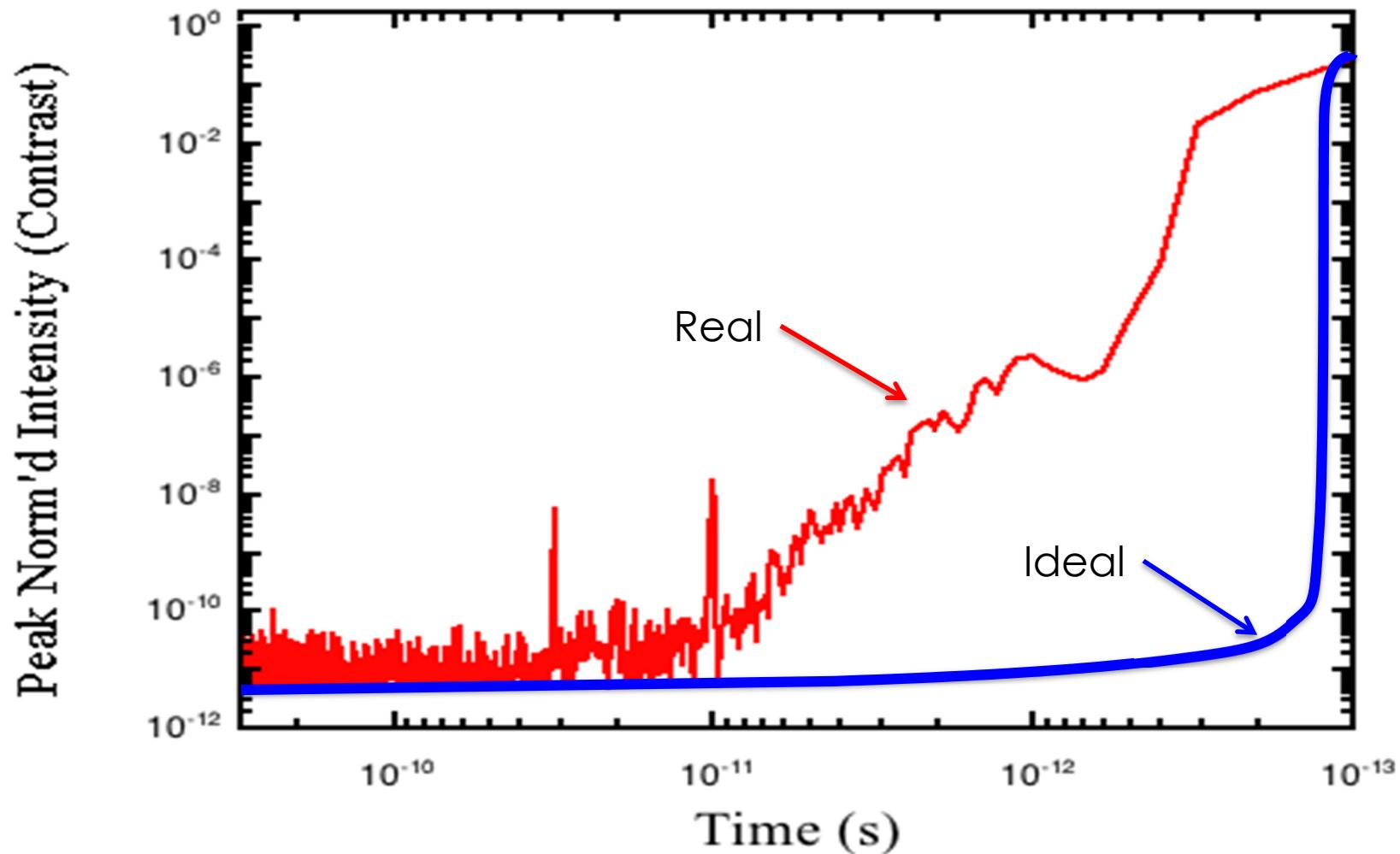


A. PIROZHKOVA et al., Optics Express 25, 17 (2017)

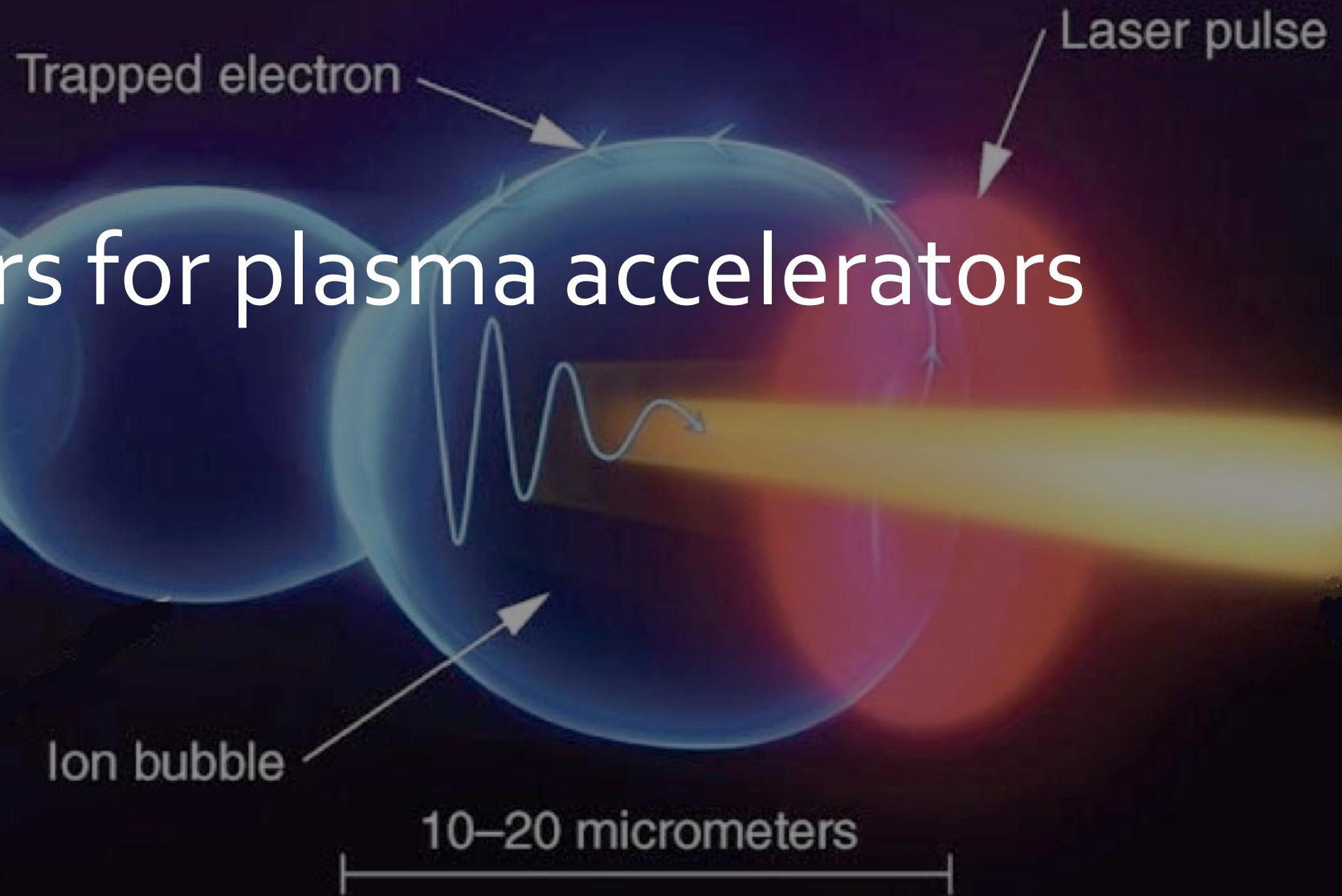
TEMPORAL FEATURES: CONTRAST



LASER CONTRAST: SUB-PS TIME SCALE



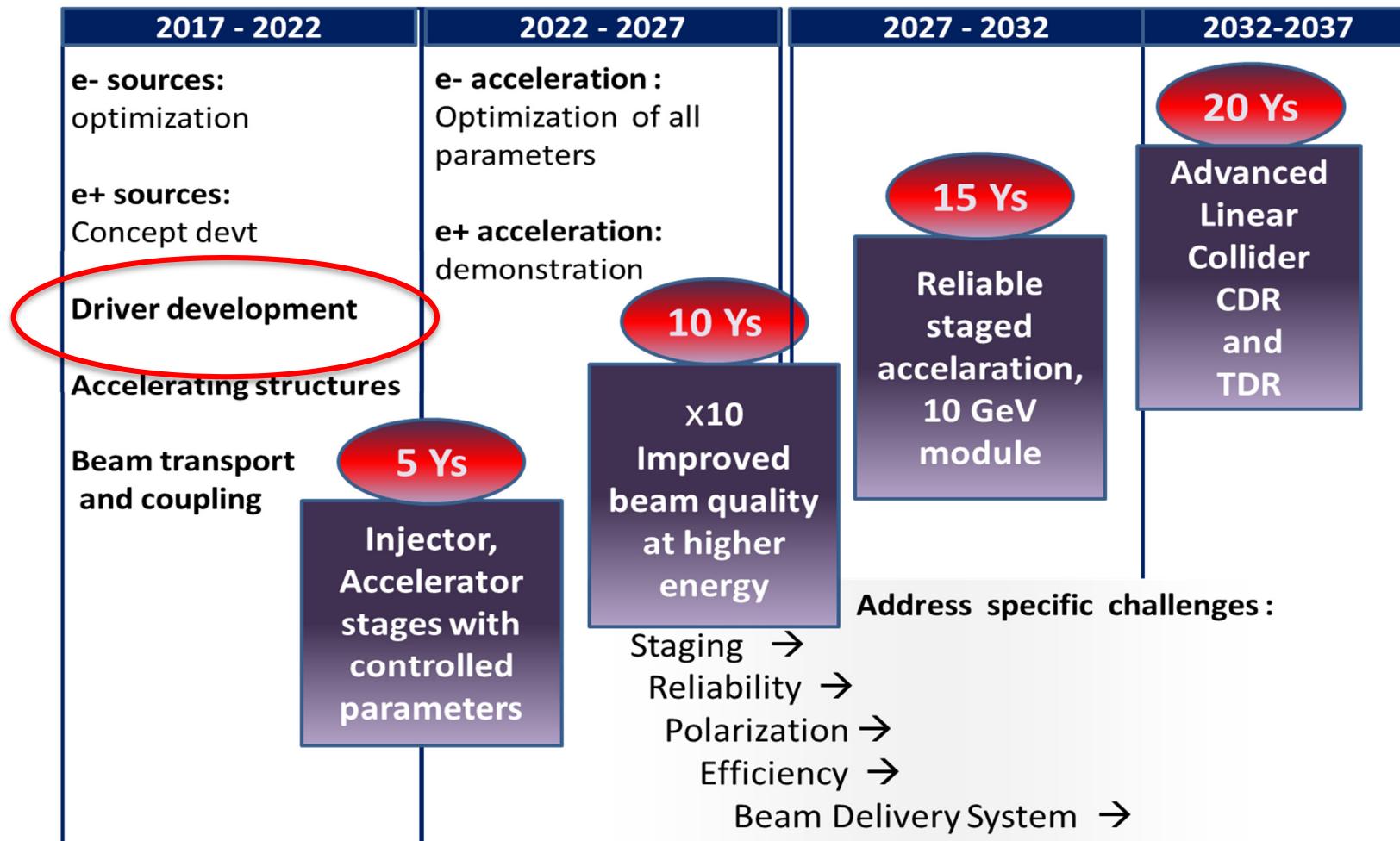
Lasers for plasma accelerators



Roadmap of Advanced and Novel Accelerators



International Committee for Future Accelerators
Panel on Advanced and Novel Accelerators





EUROPEAN PLASMA RESEARCH ACCELERATOR WITH EXCELLENCE IN APPLICATIONS

The EuPRAXIA Project:
**COMPACT EUROPEAN PLASMA
ACCELERATOR WITH SUPERIOR
BEAM QUALITY**



This project has received funding from the European Union's Horizon 2020 research and innovation programme under grant agreement No 653782.

<http://eupraxia-project.eu>

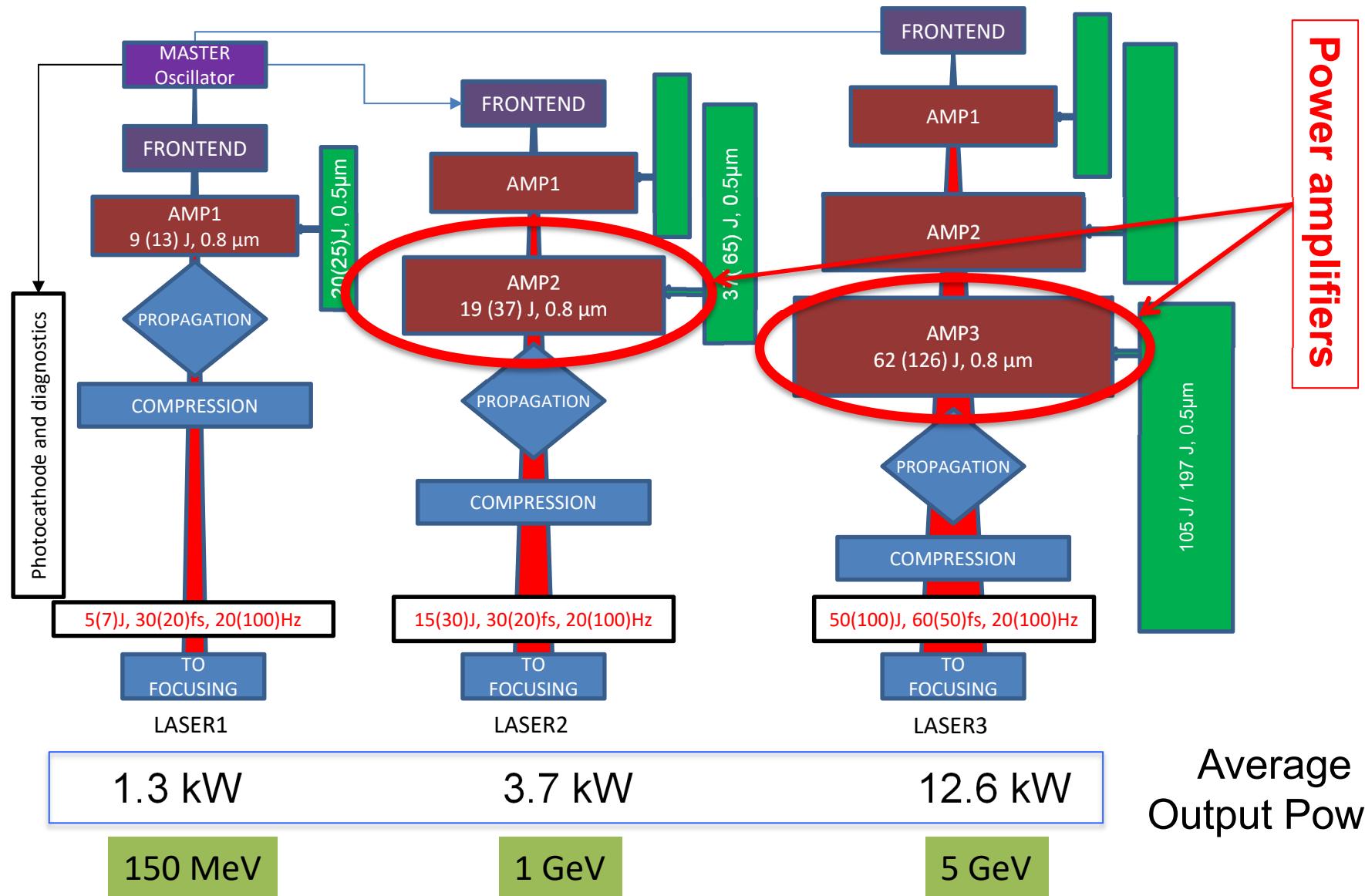
- EuPRAXIA is a **conceptual design study** for a **5 GeV electron plasma accelerator** as a European research infrastructure.
- FEL requires low (**total**) energy spread (**<1%**) and low emittance (**<1mm mrad**):
 - Validate technical components and schemes in plasma accelerator concepts producing already GeV class beams:
 - Establish laser driver technology
 - *Combine efforts with **laser industry and laser institutes** to improve rep. rate & efficiency (incorporate all viable laser technologies with higher efficiency).*

Laser Driver 5 GeV (Laser 3)

Parameter	Label	P0*	P1**
Wavelength (nm)	$\lambda_2 \text{ (nm)}$	800	800
Maximum energy on target (J) *	E_2	50	100
Energy tuning resolution (% of targeted value)	dE	7	5
Shortest pulse length (FWHM) (fs)	τ_2	60	50
Repetition rate (Hz)	f_2	20	100
Contrast at 100 ps	$C_1(100 \text{ ps})$	1,00E+11	1,00E+12
Contrast at 50 ps	$C_1(50 \text{ ps})$	1,00E+10	1,00E+11
Contrast at 10 ps	$C_1(10 \text{ ps})$	1,00E+10	1,00E+10
Contrast at 1 ps	$C_1(1 \text{ ps})$	1,00E+06	1,00E+08
Contrast at 100 fs	$C_1(100 \text{ fs})$	1,00E+02	1,00E+03
Number of beams	N_2	1	1
Synchro. to global reference (P-V) (fs)	$\sigma_{\Delta t}$	10	5
Beam intensity distribution (x-y) in focal plane	-	Gaussian	Supergaussian (n=10)
Polarization in focal plane	P_1	linear	linear, circular
Max ellipticity of focal spot (Am/AM)		0.8	0,95
Polarization purity (%)		1	1
Requirement on energy stability (RMS) %	$\sigma_{\langle E \rangle}$	5	1
Requirement on focal size & Z_L stab. (RMS) %	$\sigma_{\langle Z_L \rangle}$	10	5
Focal spot size stability (on target plane) (RMS) %	$\sigma_{\langle w_0 \rangle} / w_0$	20	10
Pointing stability (RMS) (μrad)	$\sigma_{\langle x' \rangle}, \sigma_{\langle y' \rangle}$	5	1

- **up to ten kW average laser power with PW peak power and high repetition rate;**
- **Ti:Sa technology pumped by diode-pumped solid state (DPSSL) lasers provides a relatively safe ground, with major industrial and research endeavour in place;**
- **Recent developments**, with DPSSL prototypes pump lasers offer kW performances at the required Ti:Sa pumping wavelength of 0.5 μm;

Detailed scheme



Design guidelines

- Modularity: same amplification stages in the different laser chains;
- Scalability: upgrade “simply” by increasing pump energy and rep rate
- **High extraction efficiency (esp. at P1) to reduce pump energy requirements**
- **Thermal management issues**

Design methodology

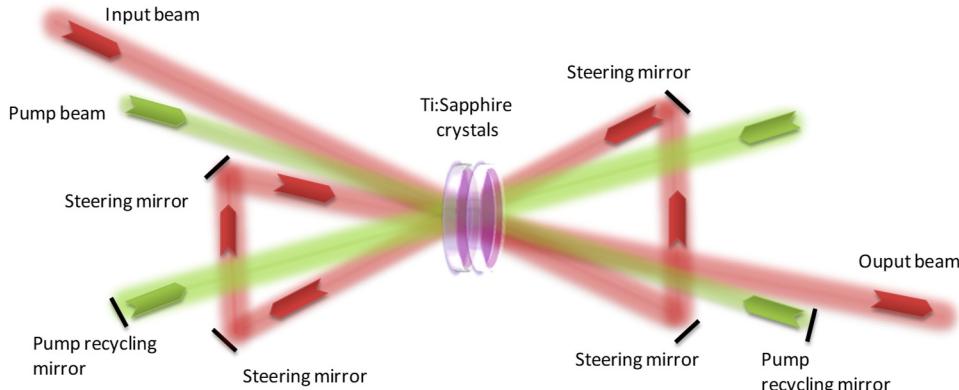
- Evaluation of the amplification parameters (energy, spectrum, beam size, stability, parasitic lasing) with **numerical simulations** (MIRO – CEA);
- Validation of modelling with existing systems up to multi-J level;
- Preliminary thermomechanical evaluation by means of FEA simulations (LAS-CAD);

Results

- Main parameters for each stage: pump energy, extracted energy, beam size, spectral shift, parasitic gain ...
- Energy stability vs pump and seed energy fluctuations
- Evaluation of thermal aberrations
- Cooling strategies: liquid flow cooling
- ASE/PL mitigation strategies: Extraction during pumping

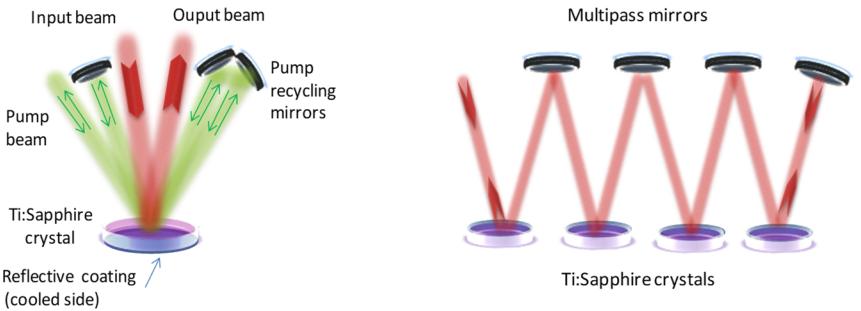
Transmission vs. “active mirror” configuration is currently being evaluated to account for thermal management

Transmission geometry

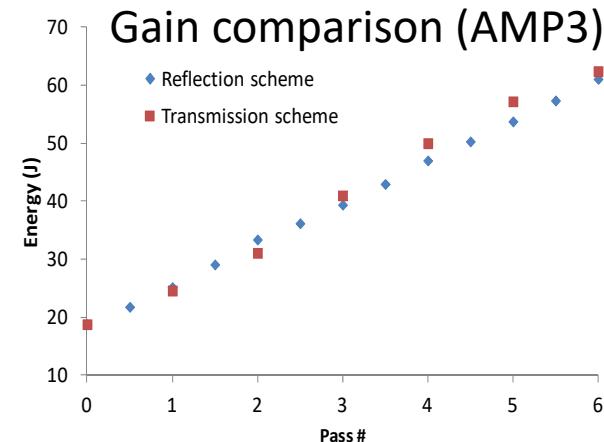


Pro: More efficient (double-side) cooling and reduced complexity;
Con: propagation through flowing cooling liquid

“Active mirror” geometry



Pro: Well established concept with no propagation through cooling fluid
Con: limited cooling (single face), to be modelled

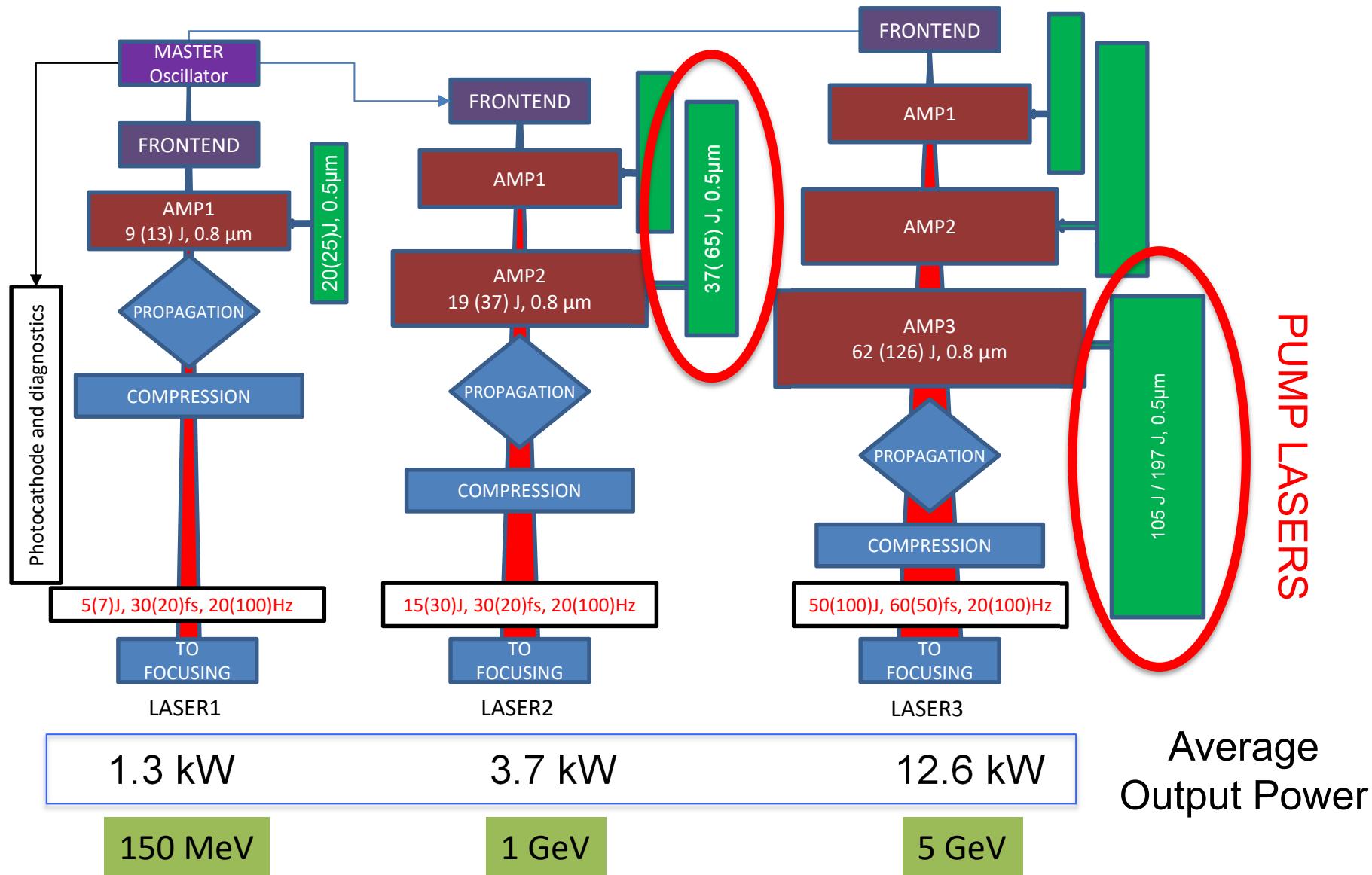


*) Water cooled Ti:Sa amplifier (“Active Mirror” configuration) under development at ELI-HU (After V. Cvhykov *et al.*, Opt. Lett, **41**, 3017, 2016)

) Fluid (D_2O) cooled Nd:YAG laser, 20 kW CW pump power, D_2O (After X. Fu *et al.*, Opt. Express, **22, 18421 (2014))

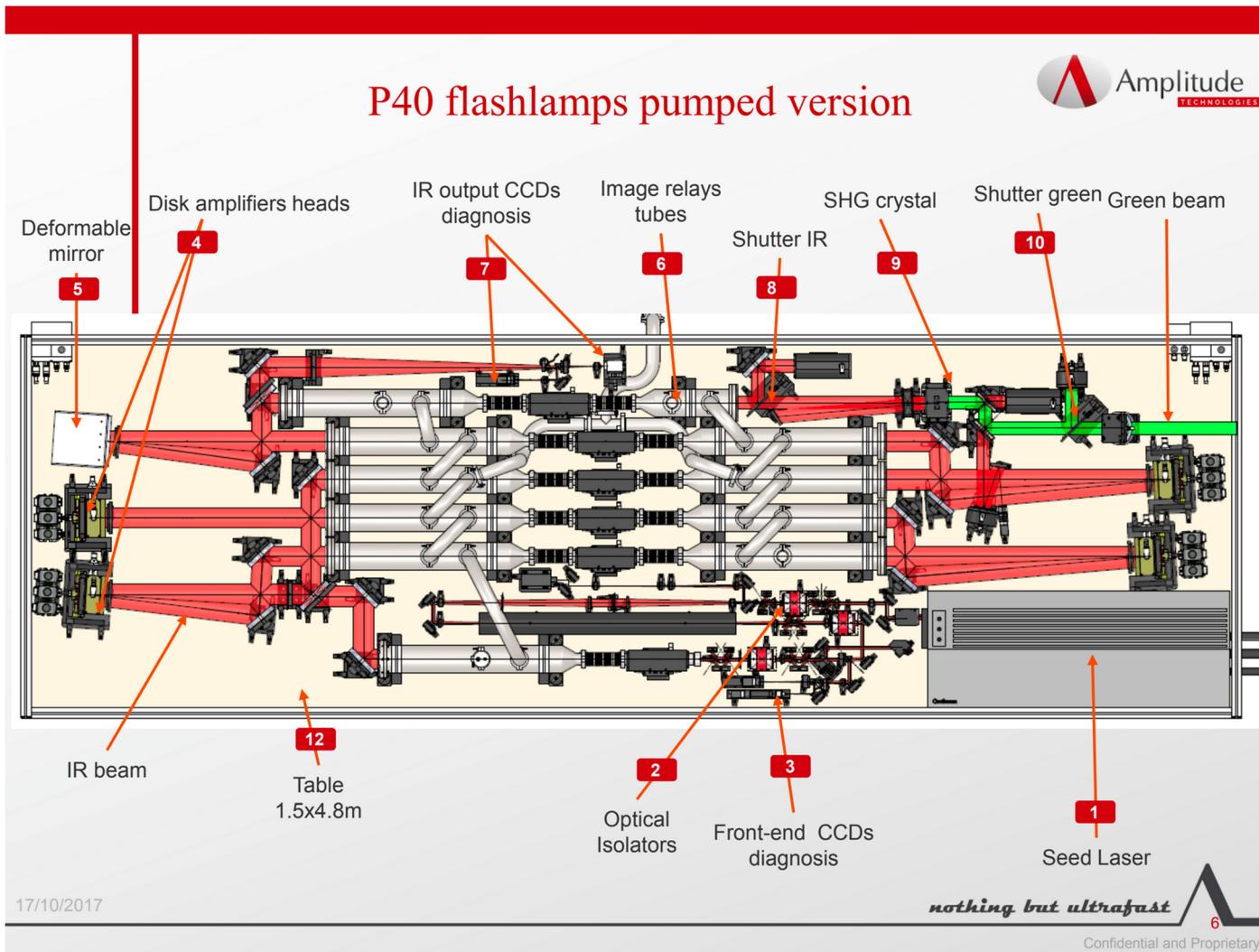
***) Fluid (Siloxane) cooled Nd:YLF laser, 5 kW CW pump power (After Z. Ye *et al.*, Opt. Express, **24**, 1758 (2016))

Detailed scheme



- **Industrial** developments of high average power pump lasers;
- DPSSL implementation on currently available **industrial** flash-lamp pumped systems for 20-50 Hz performance;
- Link to available effort in prototyping from **industry** and research labs for enhanced performance;
- **High power diode developments** for future 100 Hz / 1 kHz upgrade.

Industrial unit (P60): conversion to diode pumping fully designed



Flashlamp pumped Nd:YAG/
DPSSL possible

80 J output energy demonstrated
@ **10 Hz**, 1064 nm
60 J SHG energy @ 532 nm :
design target (**40 J** demonstrated)

- **Cost of diode still an issue** – currently 5x total (including operational) costs compared to flashlamps.
- Expected to decrease in 5-10 yrs.
- Maintenance free operation for 25-30 yrs.

- 6 x Yb:YAG slabs
- 4-pass relay-imaging design
- NF, FF diagnostics on each pass



Konoshima Chemical Co.,Ltd.

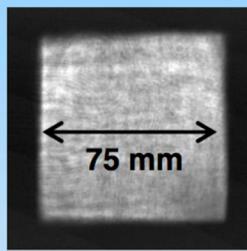
120 mm square
8.5 mm thick

10J Input

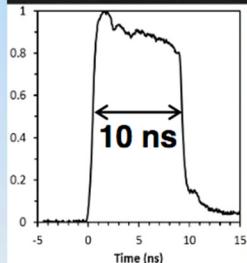
CFD: 150K
140 g/s

$\Delta T \sim 4K$

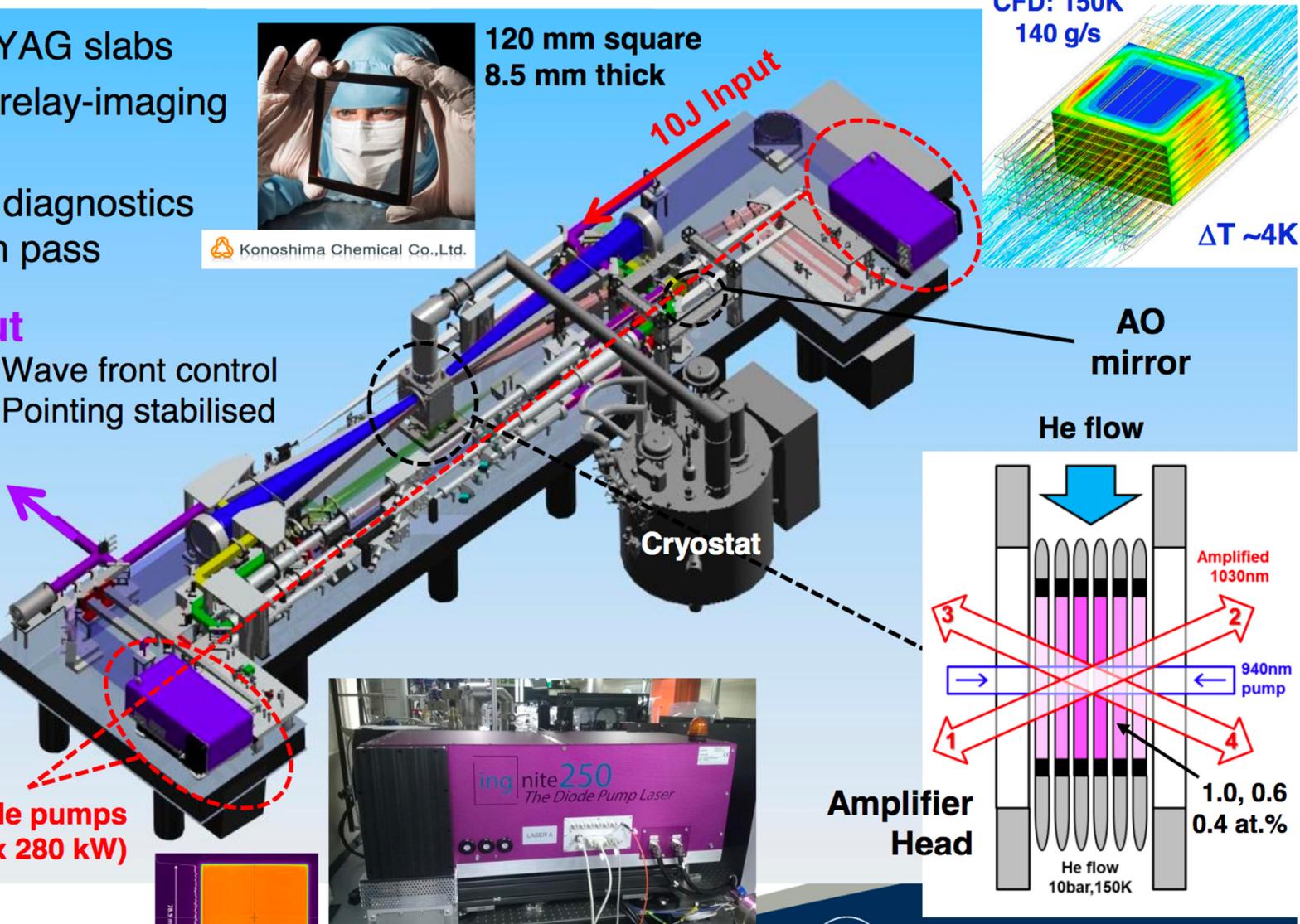
100J output



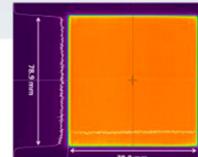
Wave front control
Pointing stabilised



Diode pumps
(2 x 280 kW)



DiPOLE100



ingeneric



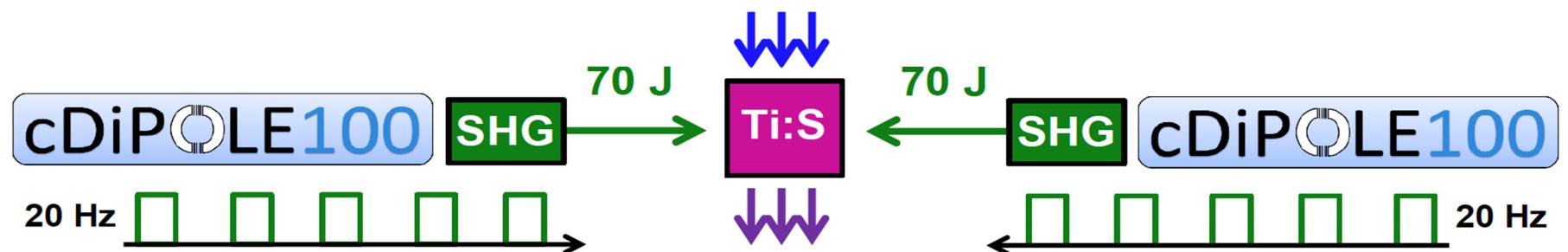
Science & Technology Facilities Council

Central Laser Facility

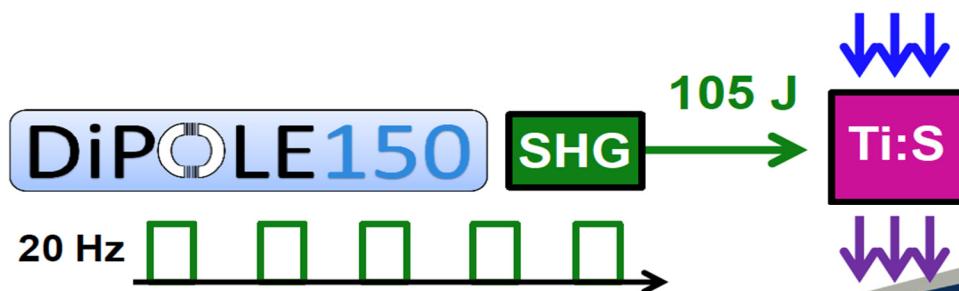
- L3 Baseline: 105 J @ **515 nm**, 20 Hz
 - Operate @ higher fluence \Rightarrow reduce aperture
 - Higher gain \Rightarrow fewer amplifier stages
 - Relax beam quality \Rightarrow higher thermal load (P_{avg} , PRF)
 - 2 x compact-DiPOLE100 @ 20 Hz (5.5 kW load)

Compact

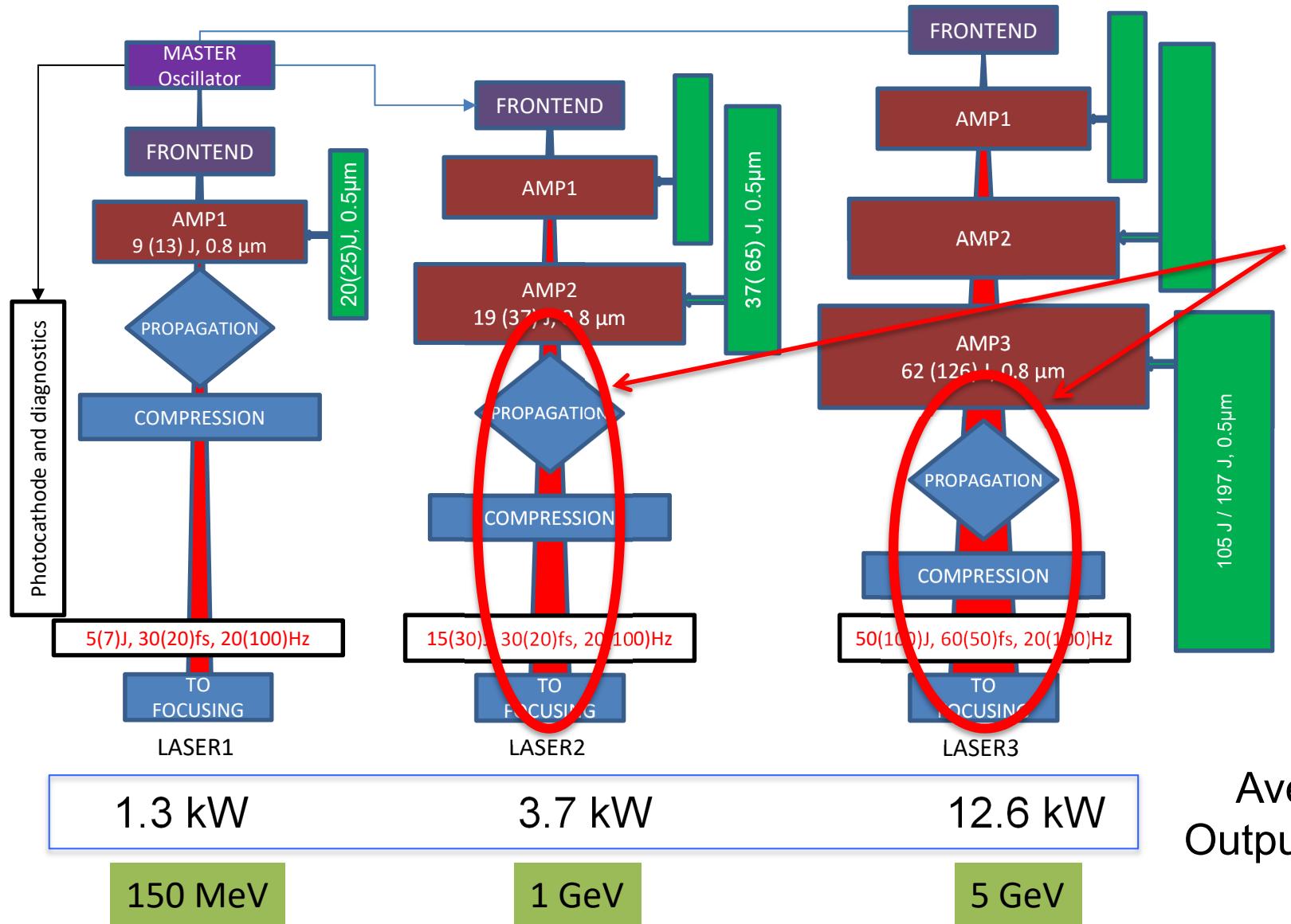
Simpler & more affordable



or 1 x DiPOLE150 @ 20 Hz (8 kW load)

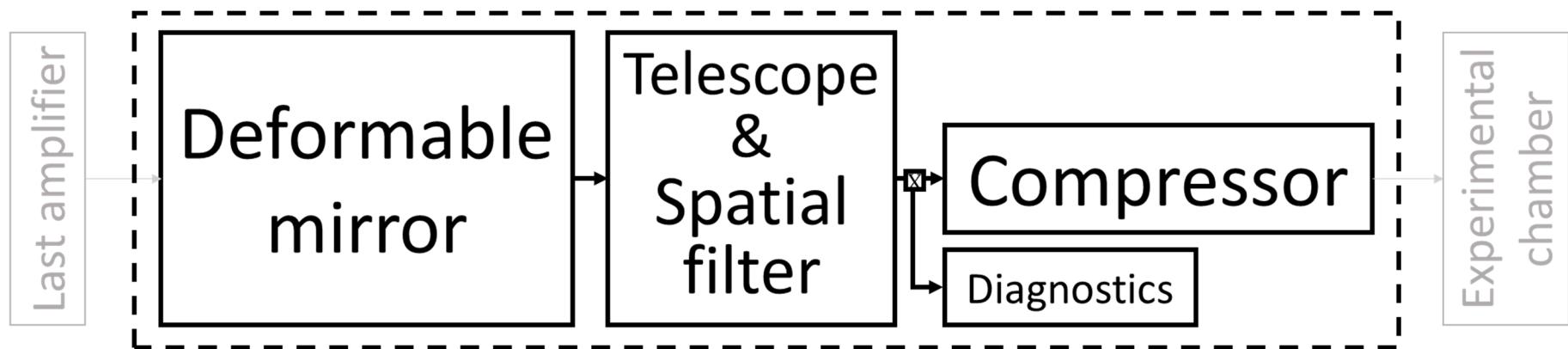


Detailed scheme

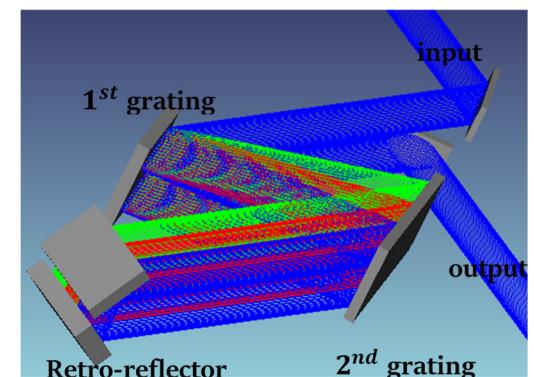
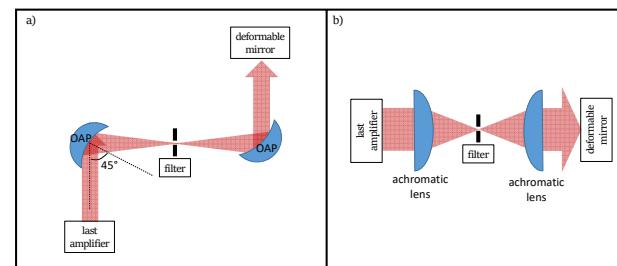
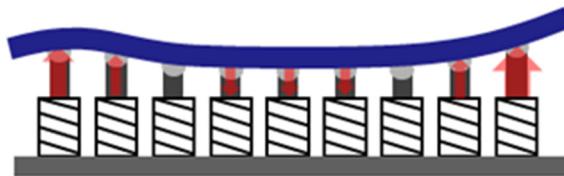


Average
Output Power

Main challenges: large optics, **mechanical stability**, **cooling of gratings**, beam quality control, **beam pointing stability** ...

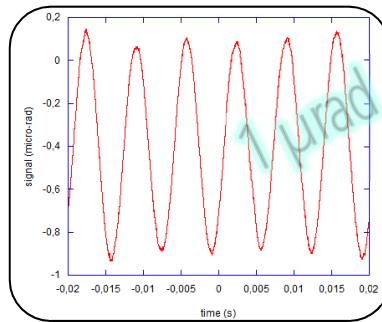
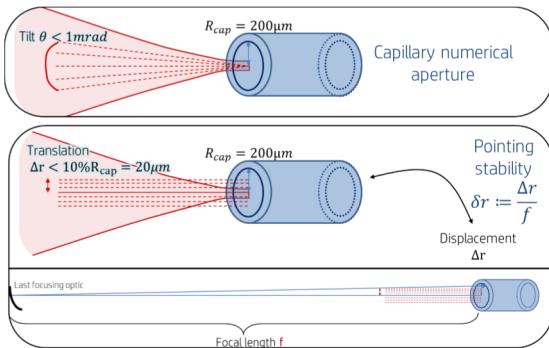


R&D at existing laser labs (APOLLON(FR), RAL(UK), ILIL(IT) etc ...)

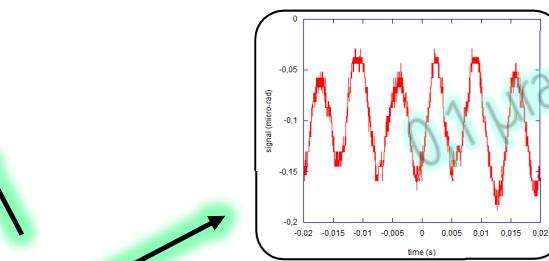


POINTING STABILITY

Requirements for beam pointing stability are extremely demanding ($1\text{-}5 \mu\text{rad}$). Both passive and active control will be required. Prior to the implementation of control strategies, tools are being developed to **measure pointing stability** performances at EuPRAXIA facilities and labs.

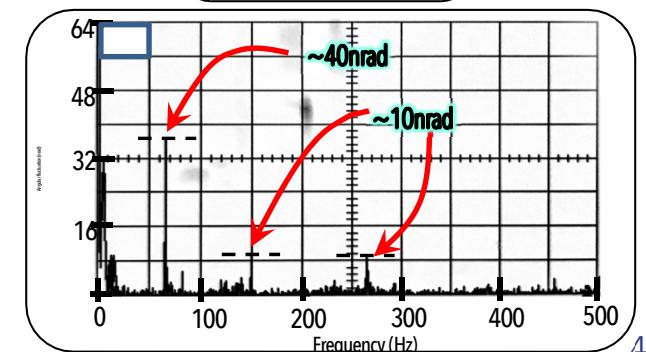


Laser angular fluctuations footprints
at 150 Hz



Environmental
angular noise of
about 30 nano-rad

up to the MHz regime
and more



Spectral analysis of the laser
fluctuation.

We already detect
<100nrad fluctuations

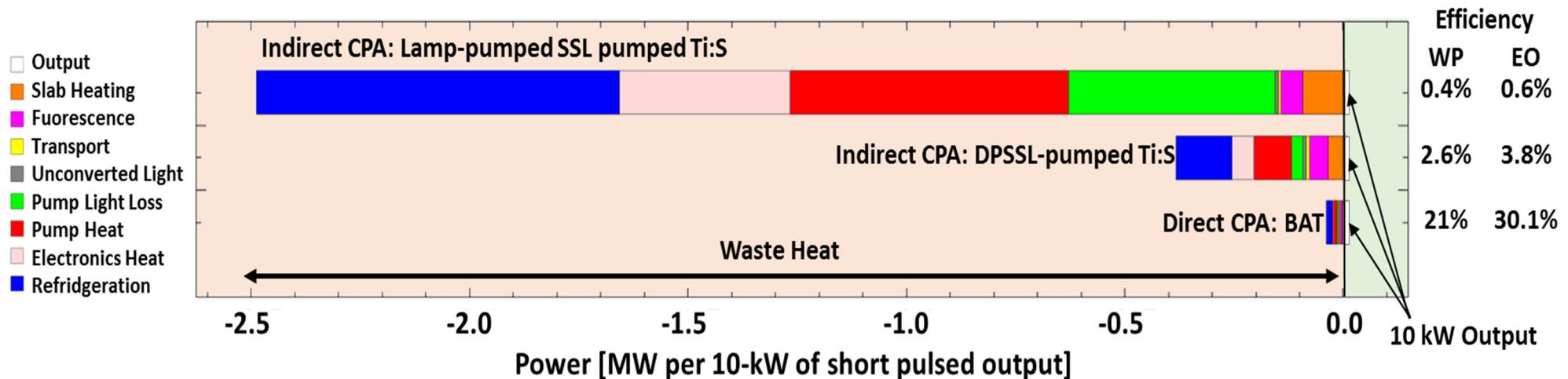
Z. Mazzotta, F. Mathieu
in collaboration with
S. Cialdi, D. Cipriani, S. Capra
of Università degli studi di Milano.

- Laser driver for a plasma accelerator designed to **seamlessly drive** a user laser-plasma accelerator;
- Current required drivers, 100-1kHz Hz, 10-100J, is **beyond existing technologies**;
- Conceptual design relies on the **latest industrial** and lab components of high power lasers;
- 20 Hz operation relies on demonstrated components (**TRL 5 to TRL 7**);
- 100 Hz operation (**TRL2 to TRL3**) is evolving along with **diode pumping developments (prototyping)**;
- Heat management of amplifier head (**TRL3-TRL4**) requires validation at the relevant component scale.

- **Other technologies are developing** aiming at >kW, higher rep. rates, higher average power levels and even more efficient configurations (k-BELLA@LBNL, Kaldera@Desy, LEAP@CELIA ...);
- **Fiber laser technology** offers the best WPE >50% in CW mode and **coherent combination** is being developed (FSU Jena-Fraunhofer IOF and Ecole Polytechnique-Thales in France). Suited for lower energy per pulse >10 kHz or for future upgrades; see also XCAN project;
- **Direct Chirped Pulse Amplification** with lasing media **pumped directly by diodes** is ideal for higher efficiency and higher rep-rate;

- Plasma accelerators will require higher and higher repetition lasers with high efficiency. Direct pumping of lasing medium with diodes is most efficient:

Direct CPA required for >100Hz due to wall-plug efficiency limitations.



We need a **gain medium** that can support amplification on a large bandwidth and can be pumped **directly** with diode lasers.

C. Siders et al., EAAC 2017

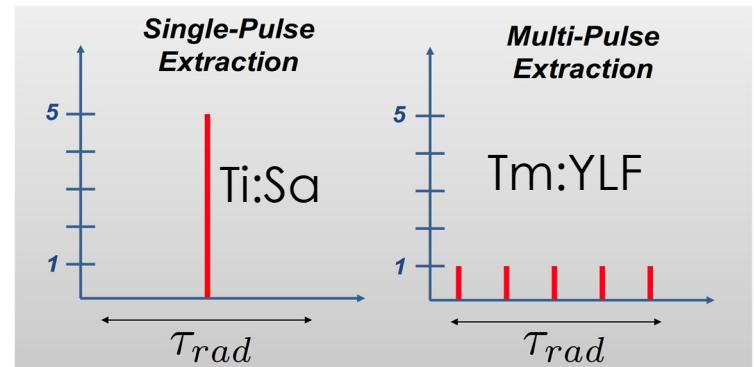
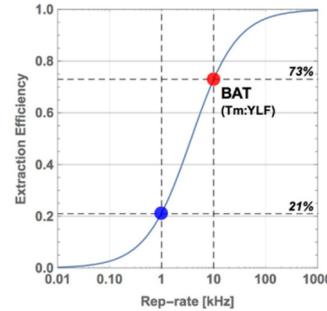
Crystals	Nd: YAG	Yb: YAG	Ti: Sa	Yb: CaF ₂
Fluorescence lifetime (ms)	0.23	0.96	0.0032	2.4
Stimulated-em. $\sigma(\times 10^{-20}/\text{cm})$	20 to 30	2.1	30	0.2
Fluorescence wavelengths (nm)	1064	1030	660-1100	1033
Absorption wavelengths (nm)	808	940	514 to 532	980
Fluorescence BW (FWHM) (nm)	0.67	10	440	70
Absorption BW (FWHM) (nm)	1.9	>10	200	10
Pumping quantum efficiency	0.76	0.91	0.55	0.5
Saturation fluence (J/cm ²)	0.67	9.2	0.9	80
Thermal conductivity (W/m/°K)	0.14	11	35	9.7
dn/dT (1E-6/K)	7.3	7.8	13	-11.3

- Available direct CPA concepts (Yb:CaF₂, Yb:YAG ...) limited in pulse duration, heat extraction and scaling;
- Developments in progress also with Tm:YLF

A possible solution: Tm:YLF

- **Currently under investigation(*):** Tm:YLF

- Emission at $1.9\text{ }\mu\text{m}$, eye safe;
- Ultrashort pulse ($<100\text{ fs}$);
- High peak power $\approx \text{PW}$;
- High average power (scalable from kW to 300 kW);
- Direct pumping at 808 nm , using diodes operating in CW mode (available and scalable);
- Multi-pulse extraction at high repetition rate $> 10\text{ kHz}$; Ideal for accelerator technology;
- High efficiency;
- Mature material technology (crystal growth);



Tm: YLF Full specifications

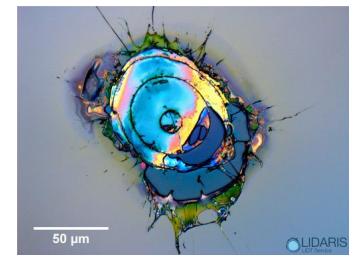
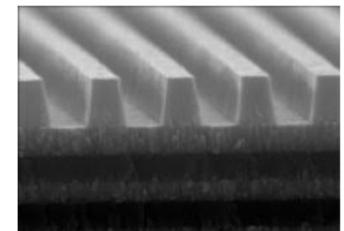
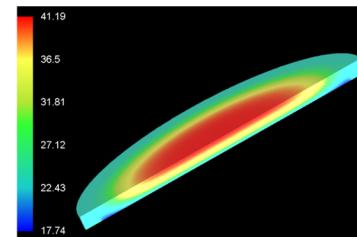
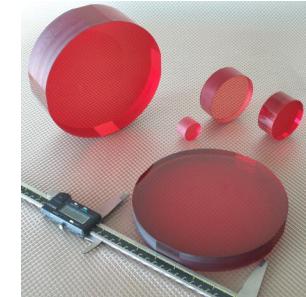
Absorption peak wavelength	792 nm
Absorption cross-section at peak	$0.55 \times 10^{-20}\text{ cm}^2$
Absorption bandwidth at peak wavelength	16 nm
Laser wavelength	1900 nm
Lifetime of $3F4$ thulium energy level	16 ms
Emission cross-section @ 1900 nm	$0.4 \times 10^{-20}\text{ cm}^2$
Refractive index @ 1064 nm	$n_o=1.448, n_e=1.470$
Crystal structure	tetragonal
Density	3.95 g/cm^3
Mohs' hardness	5
Thermal conductivity	$6\text{ W m}^{-1}\text{ K}^{-1}$
dn/dT	$-4.6 \times 10^{-6}\text{ }(^{/c})\text{ K}^{-1}$
Thermal expansion coefficient	$10.1 \times 10^{-6}\text{ }(^{/c})\text{ K}^{-1}$
Typical doping level	2-4 at.-%

High Efficiency enabled by multipulse extraction

Relatively new approach for short pulse operation: needs R&D, but promising

EuPRAXIA laser relies on industrial development in:

- Pumping technology: diode (direct or indirect) pumping;
- Gain media: material should be industrially available at laser quality, scalable in size and capable of supporting large bandwidth and efficient cooling;
- Grating technology to improve for higher damage threshold and smaller beam size
- Optics Damage threshold
- Thermal load, management, dissipation
- Vacuum technology
- Mechanical stabilization (active and passive);



Major R&D and technology transfer to embed in final systems

SUMMARY

- *Nobel winning, ultraintense CPA laser technology:*
 - *30+ years of impressive developments;*
 - *Correlated progress of laser-plasma acceleration;*
 - *FEL-quality Laser-Plasma acceleration approaching;*
 - *Today's technology leading to viable driver (EuPRAXIA);*
 - *Progressing towards kW-kHz with higher efficiency;*
 - *Building a credible route for first generation of high quality, laser-driven plasma accelerators.*

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THANK YOU FOR YOUR ATTENTION

